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Theory of the Ion Beam Induced Charge Technique (IBIC).

Trieste 14.08.2012



Bibliography

Books:

M.B.H. Breese, D.N. Jamieson, P.J.C. King, "Materials Analysis Using a Nuclear Microprobe", John Wiley and Sons, 1996

Articles:

M. B. H. Breese, E. Vittone, G. Vizkelethy, P.J. Sellin, "*A review of ion beam induced charge microscopy*", Nuclear Instruments and Methods in Physics Research B 264 (2007) 345–360. See slides

Links:

http://www.dfs.unito.it/solid/RICERCA/IBA/IBA index.html

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Theory of the Ion Beam Induced Charge Technique (IBIC).

From nuclear spectroscopy to material analysis

- Principles of IBIC
- From spectroscopy to microspectroscopy
- Basic equations
- Validation of the theory
- Charge sharing

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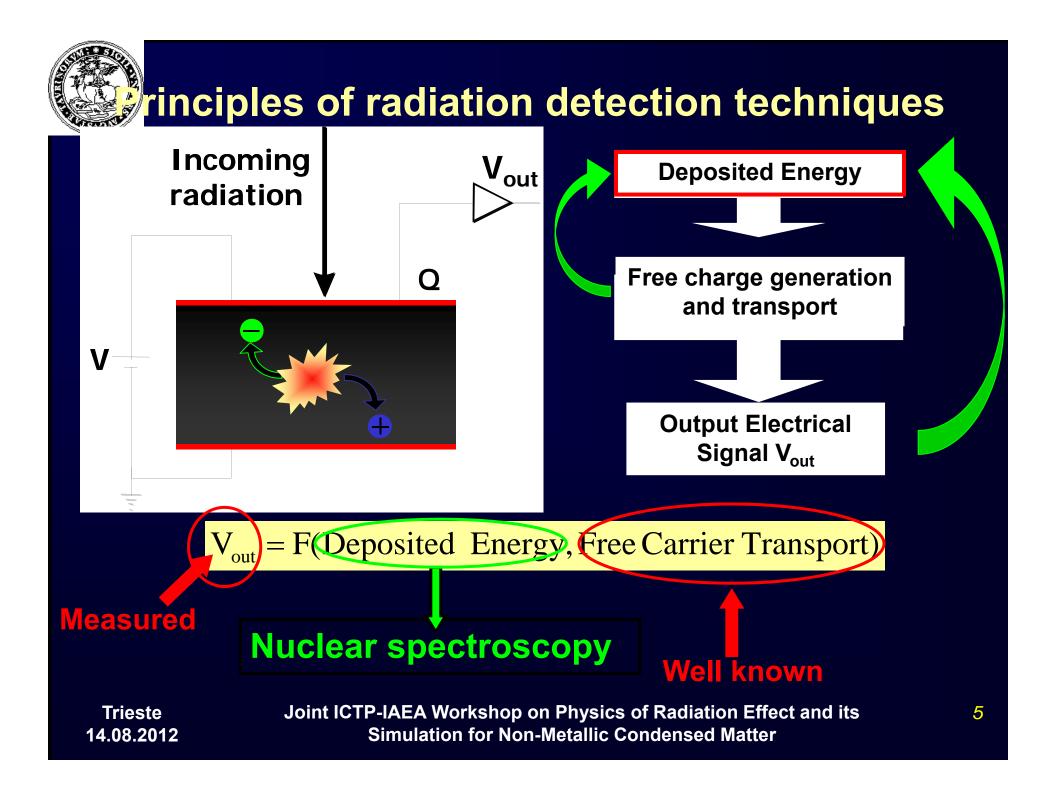
IBIC for the functional characterization of semiconductor materials and devices

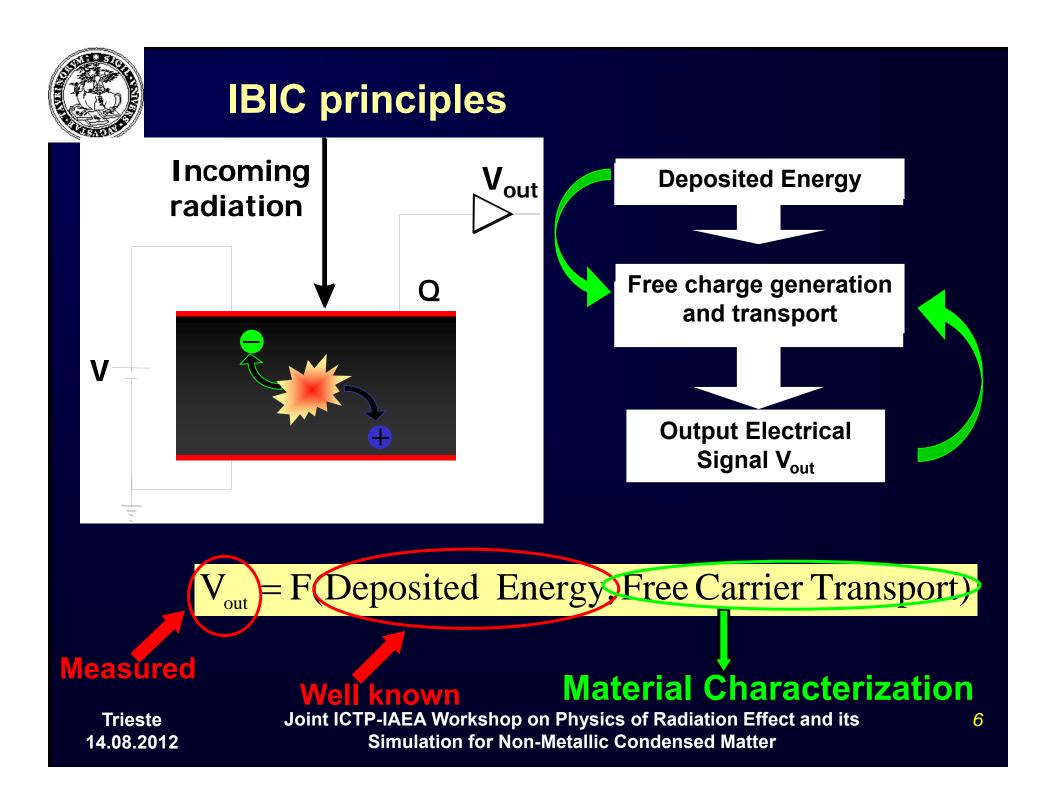
Measurement of the their electronic properties and performances

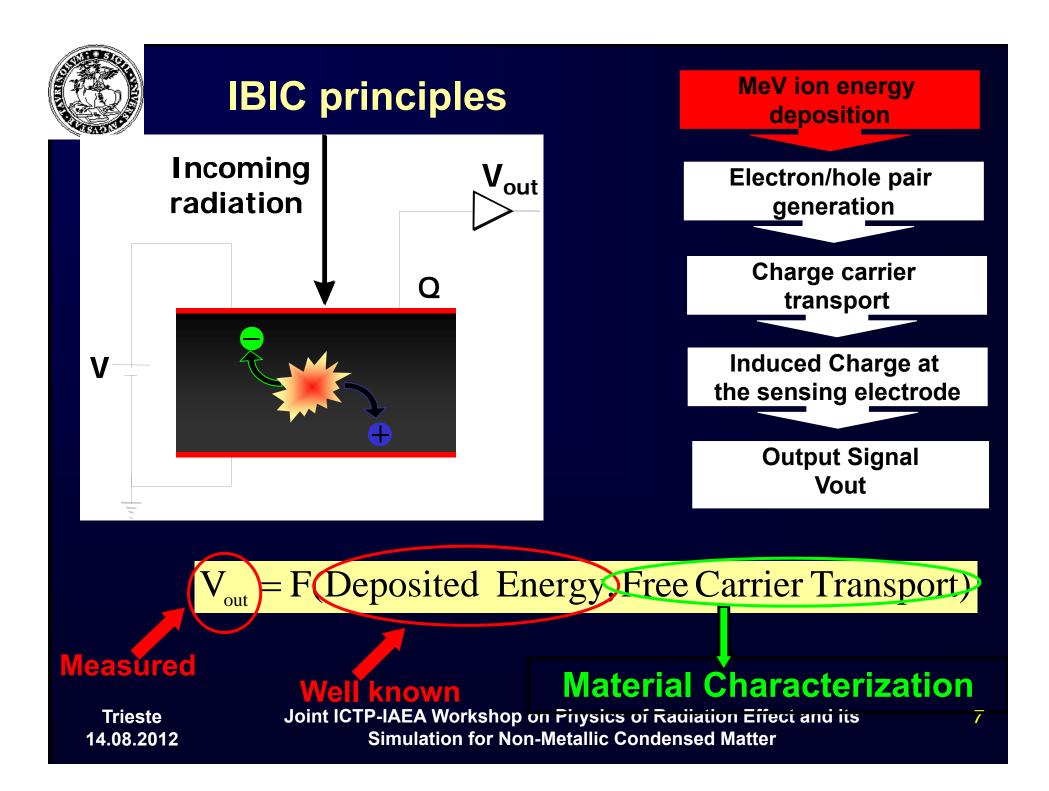
Main physical observable: current Current = F(carrier_density; carrier_transport)

Carrier generation by MeV ions Generation profile Recombination/trapping Carrier lifetime **T** Free carriers (electron/hole) transport Two mechanisms: Drift \Rightarrow electric field $v=\mu\cdot E$ Diffusion \Rightarrow concentration gradient

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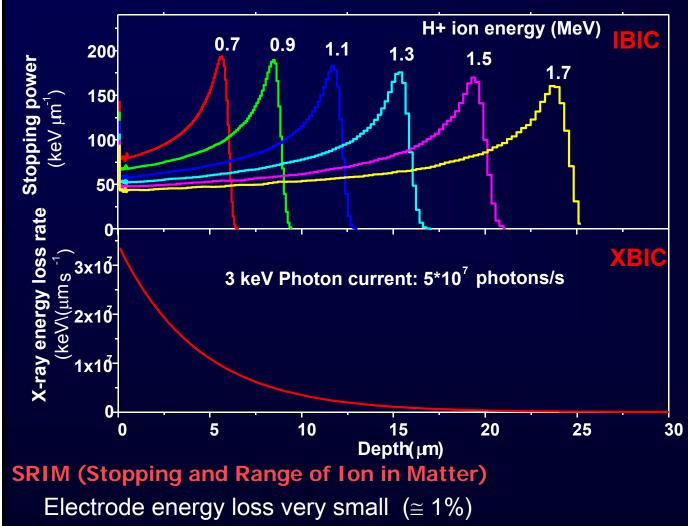






Using MeV ions to probe

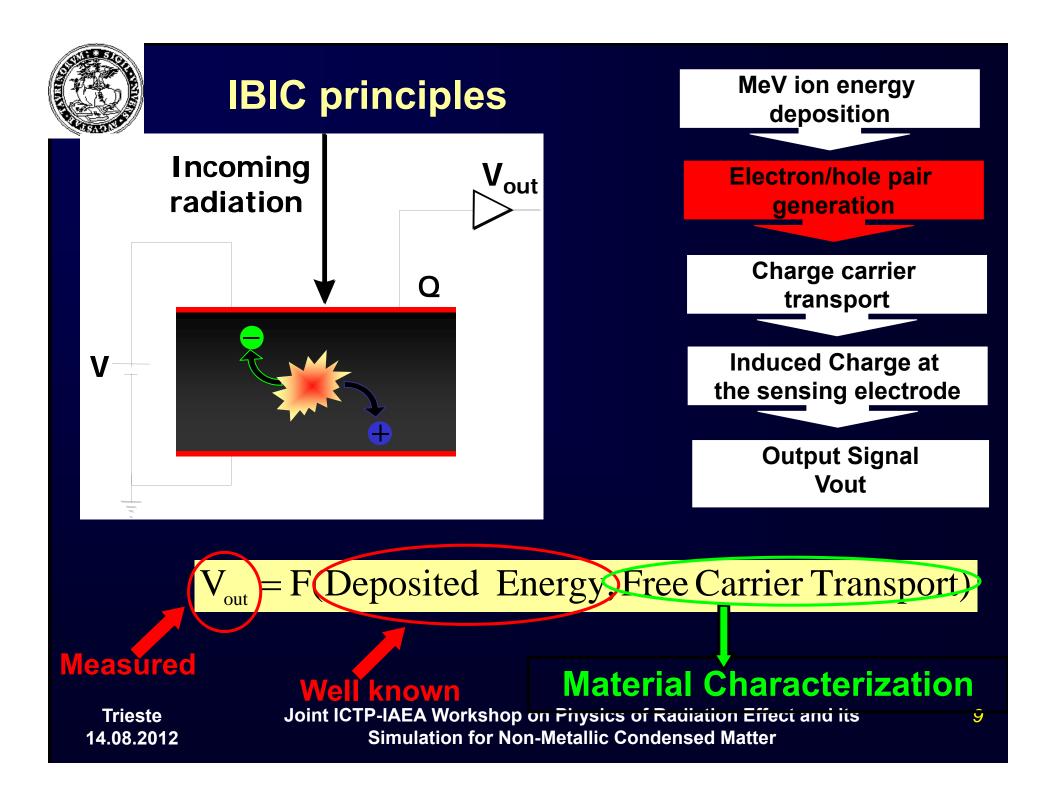
the electronic features of semiconductors



➢ long range **≻low** lateral scattering ➤a wide choice of ion ranges and electronic energy losses ✓ analysis through thick surface layers ✓ charge pulses height spectra almost independent on topography. ✓ profiling

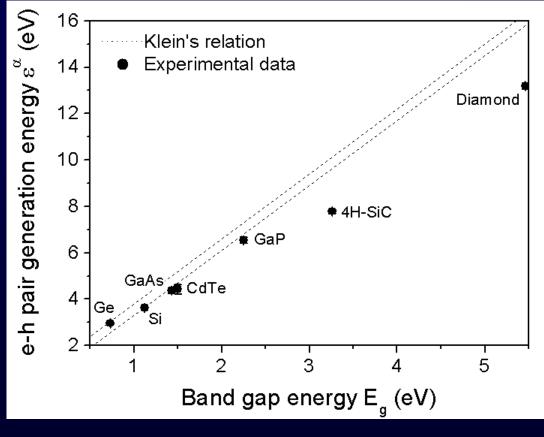
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18.0





Electron/Hole pair generation



A. Lo Giudice et al. Applied Physics Letters 87, 22210 (2005)

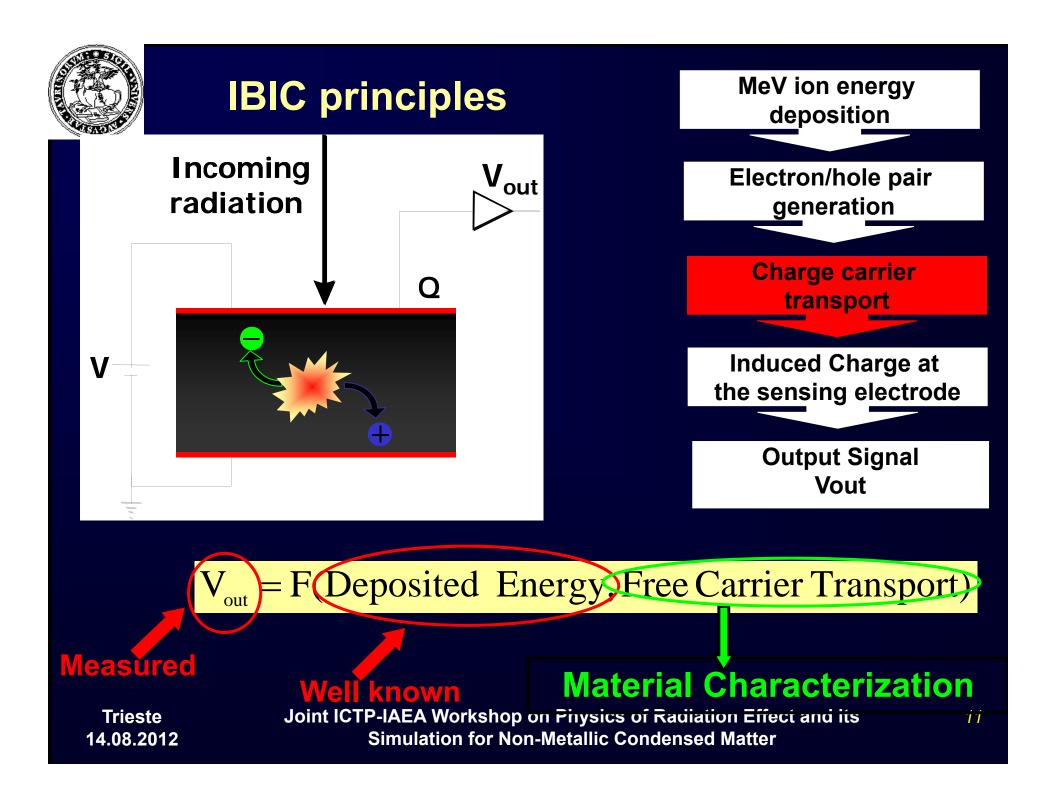
 $N_{eh} = rac{E_{ion}}{\epsilon_{eh}}$

ε_{eh}=average energy expended by the primary ion to produce one electron/hole pair

1 MeV ion in diamond generates about 77000 e/h pairs

Each high energy ion creates large numbers of charge carriers to be measured above the noise level.

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J.R. Haynes, W. Shockley,

"The mobility and life of injecting holes and electrons in germanium,

Phys. Rev. 81, (1951), 835-843.

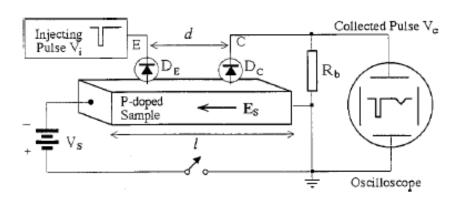
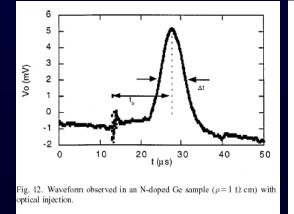
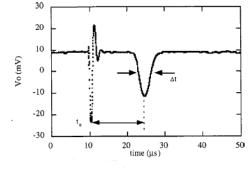


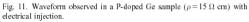
Fig. 1. Block diagram of the Haynes Shockley experiment: D_E and D_C are the emitter and collector point probes.

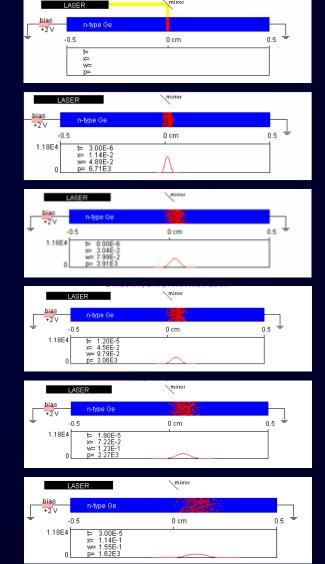


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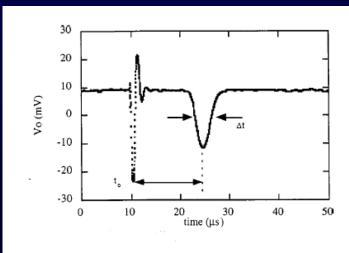
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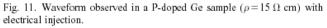


J.R. Haynes, W. Shockley, Phys. Rev. 81, (1951), 835-843.

P-doped Ge;

resistivity about 15 Ω·cm; dielectric constant =1.4pF/cm; Dielectric relaxation time = 21 ps. <u>Charge neutrality maintained</u>

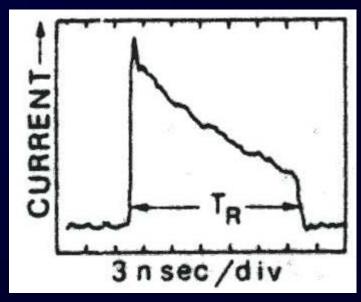




C. Canali et al., Nucl. Instr. Meth. 160 (1979) 73-77

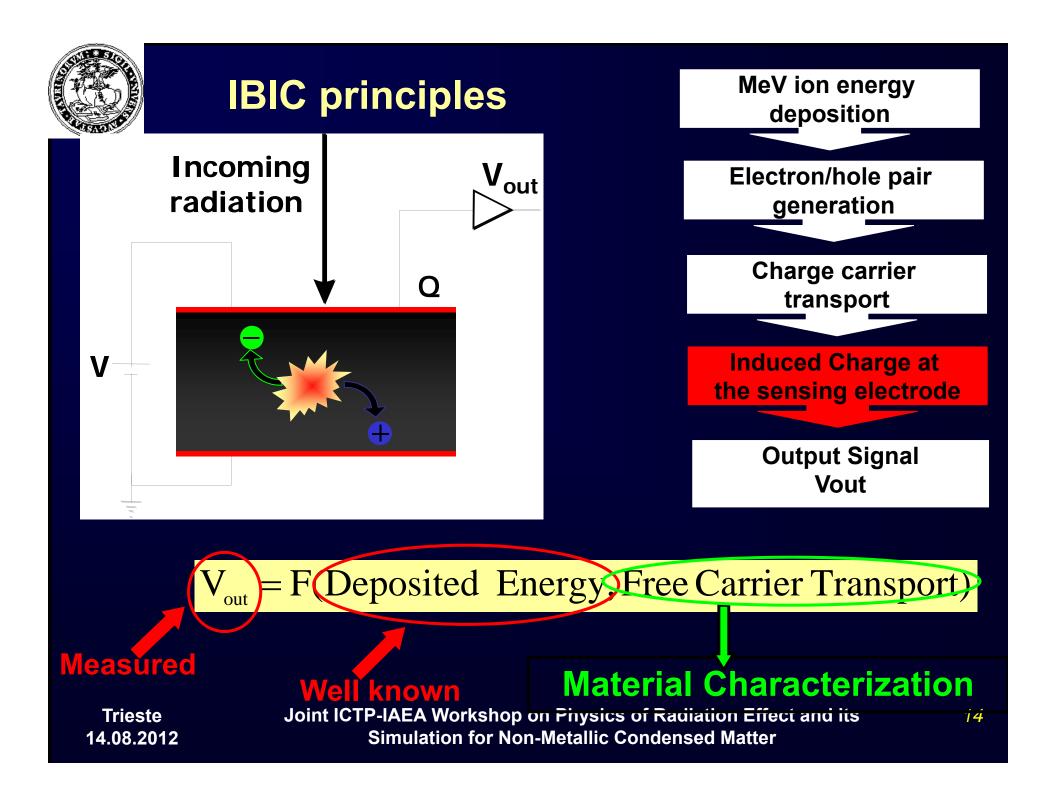
lla diamond;

resistivity about $10^{15} \Omega \cdot cm$; dielectric constant =0.5 pF/cm; Dielectric relaxation time = 500 s. <u>Charge neutrality not maintained</u>



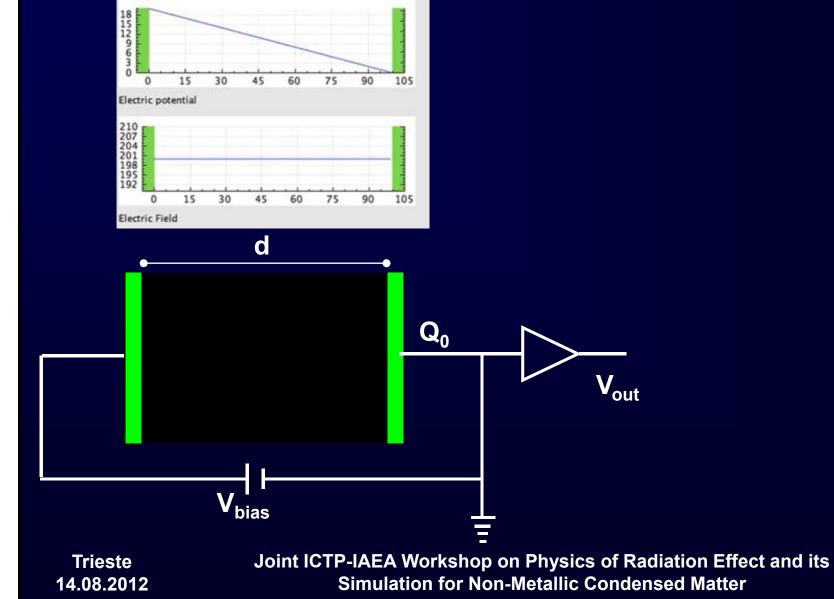
400 μ m thick natural diamond, biased at 40 V @ RT

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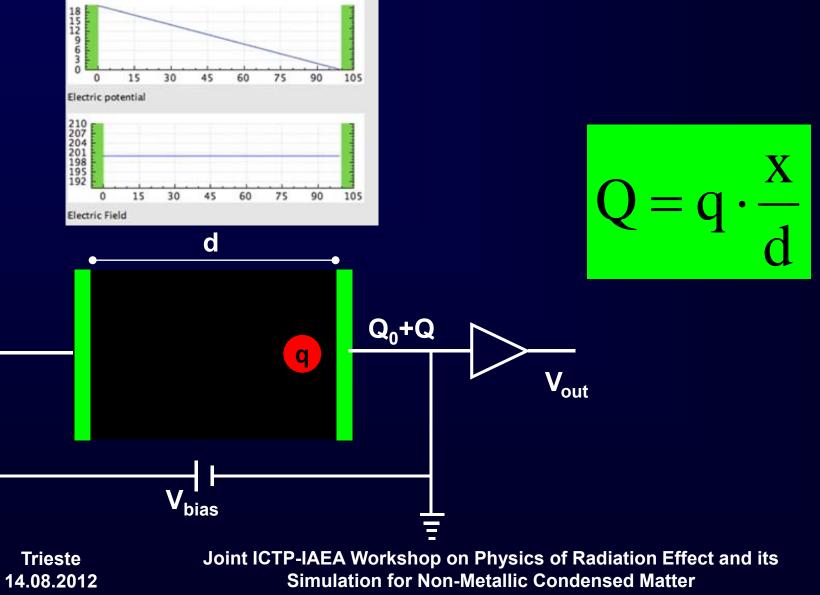




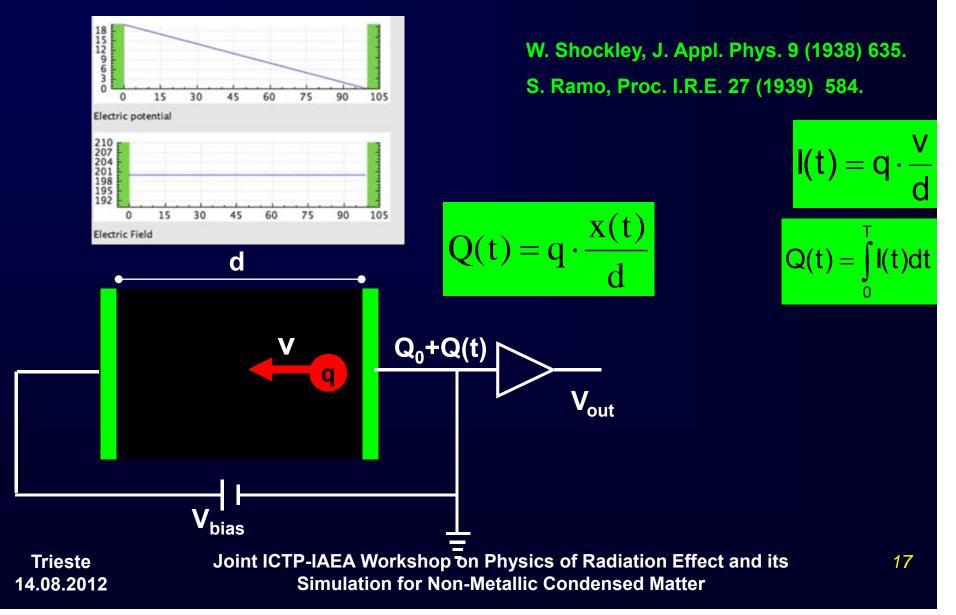
Physical Observable: Induced current/charge

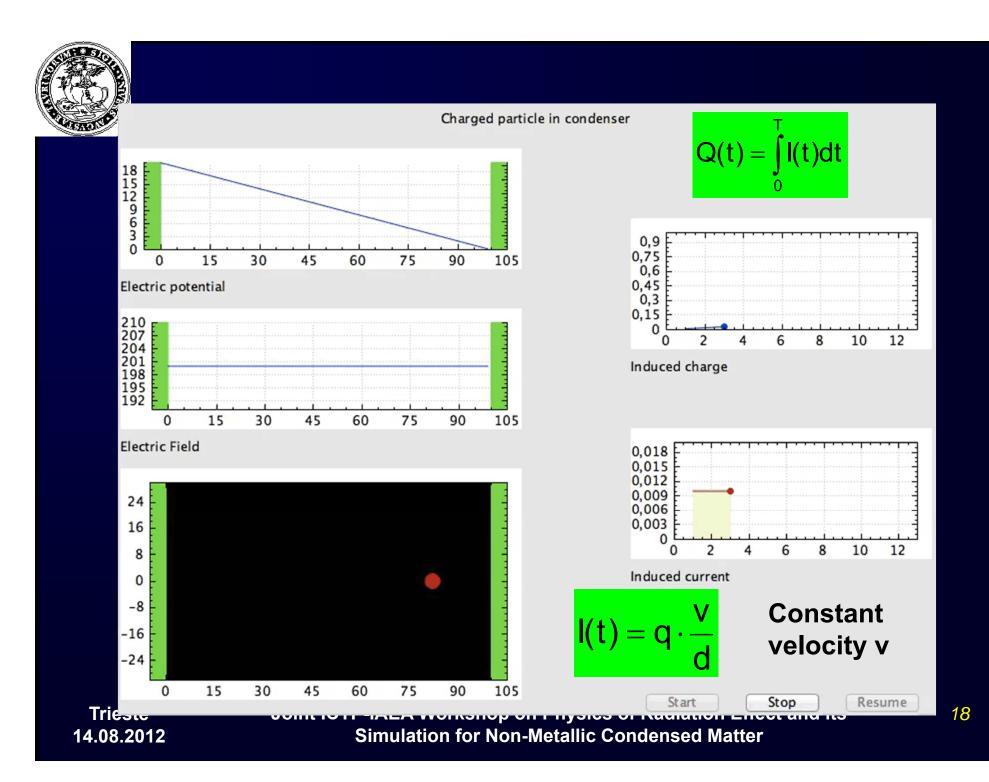


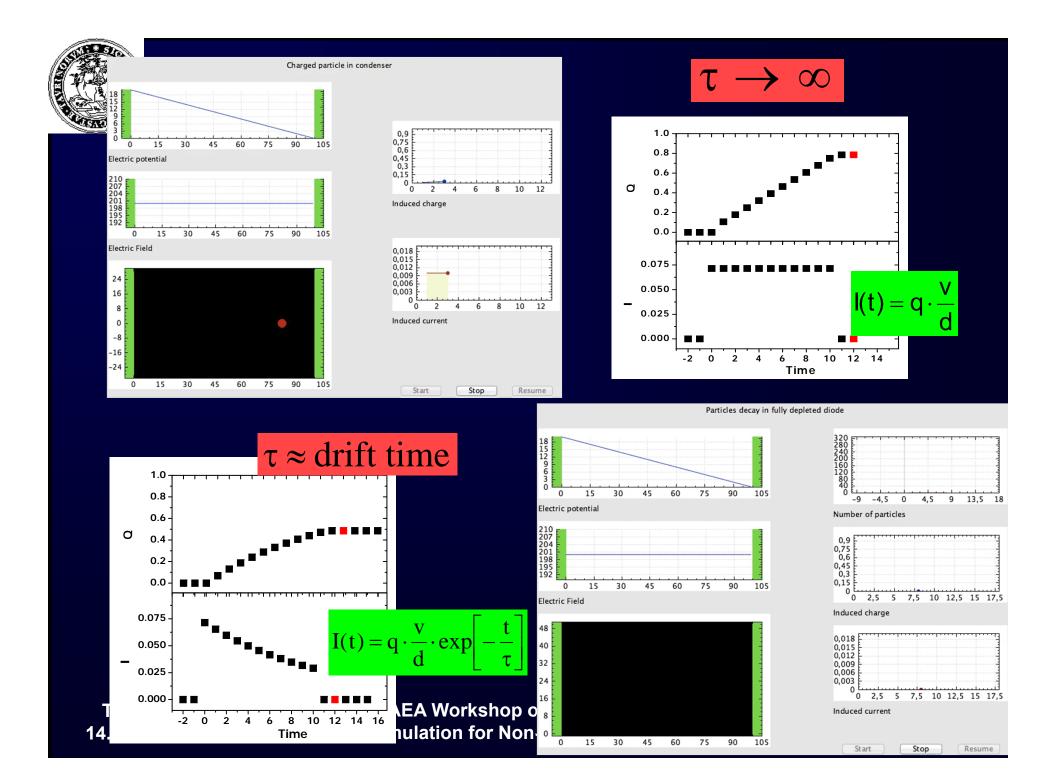




Physical Observable: Induced current/charge







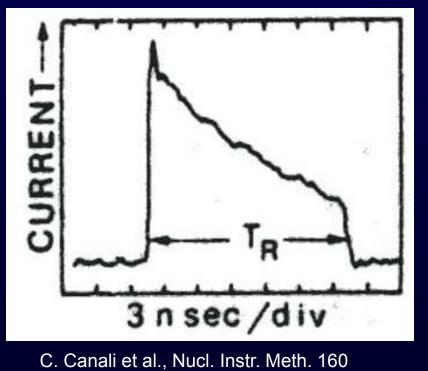


Ila diamond; resistivity about $10^{15} \Omega \cdot cm$; dielectric constant =0.5 pF/cm; Dielectric relaxation time = 500 s.

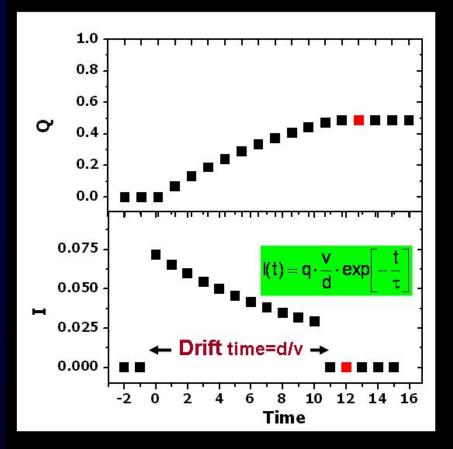
Charge neutrality not maintained

400 μm thick natural diamond,

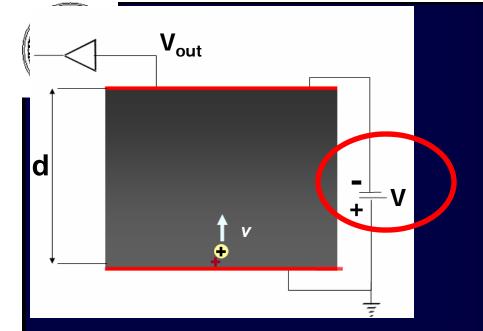




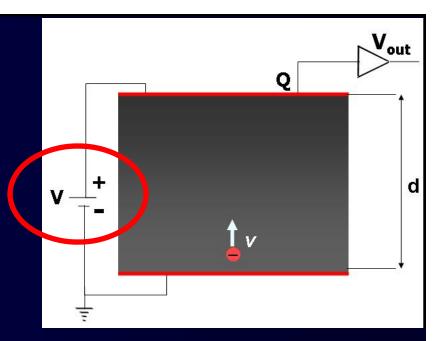
(1979) 73-77



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Generation at the anode Induced signal from the Hole motion



Generation at the cathode Induced signal from the electron motion

$$CCE \approx \frac{\mu \tau_e E}{d} \left(1 - \exp\left(\frac{-d}{\mu \tau_e E}\right) \right)$$

K. Hecht, Z. Physik 77, (1932) 23

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(cm/sec)

VELOCITY

DRIFT

10'- DIAMOND

300 K

E/ (110) ± 15"

Characterization of the transport properties in diamond

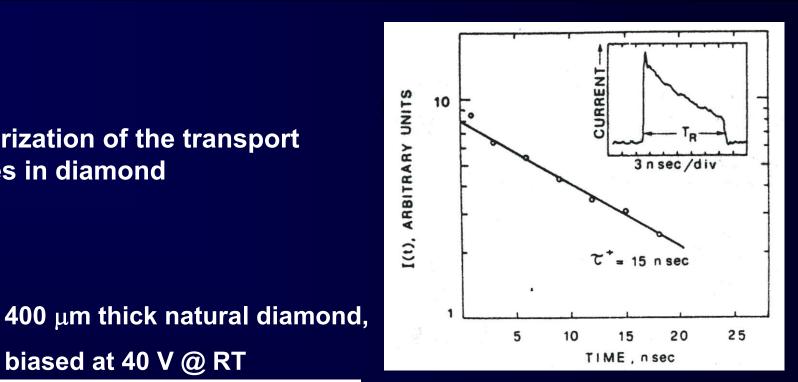
biased at 40 V @ RT

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HOLES

ELECTRONS .

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Drift velocity; $v = \mu E = d/T_R$

Mobility; $\mu = d^2/(T_R * V_{Bias})$

ELECTRIC FIELD (V/cm) -IALA Workshop on Physics of Radiation Effect and its Simulation for Non-Metallic Condensed Matter

10

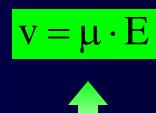
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10²

10



Shockley-Ramo Theorem

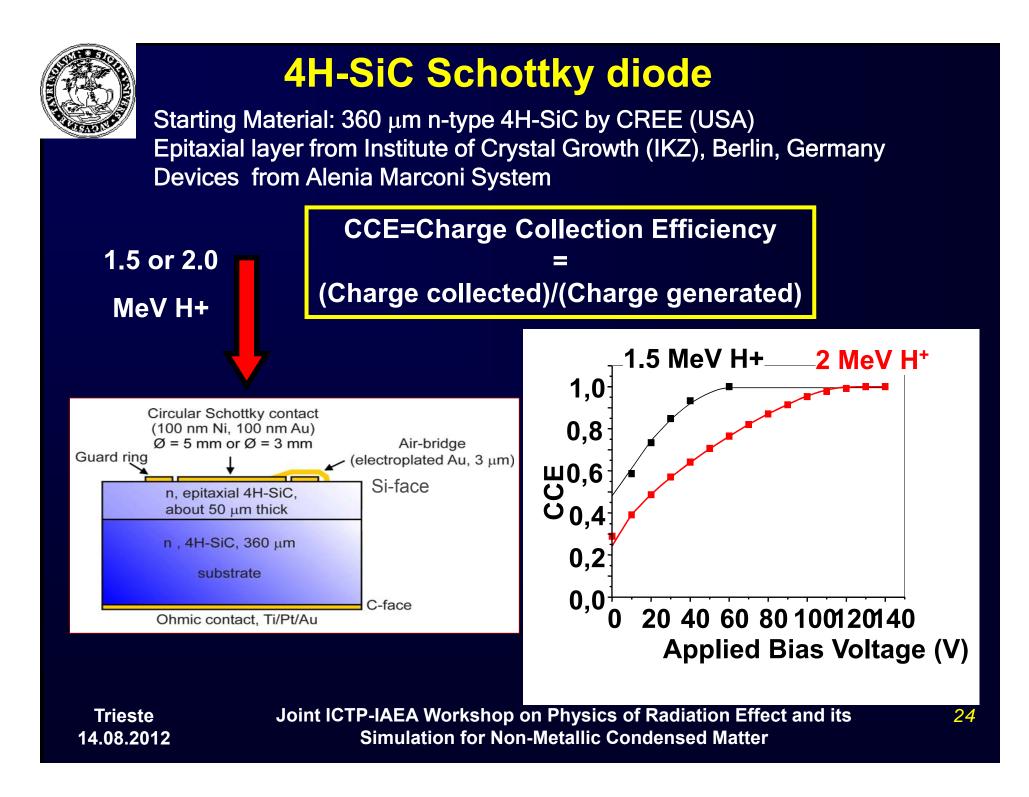


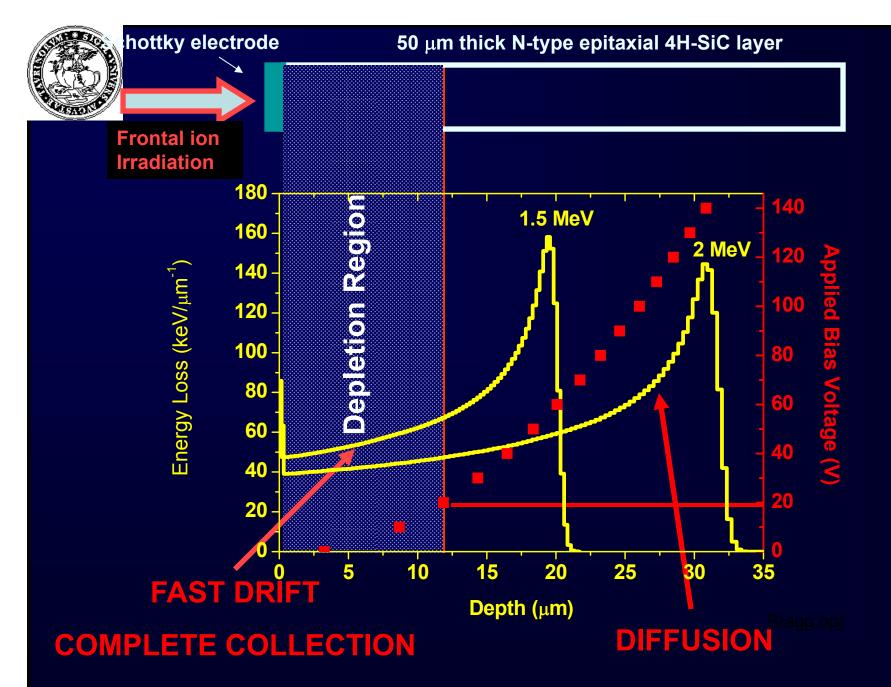
The current is induced by the motion of charges in presence of an electric field

Induced current

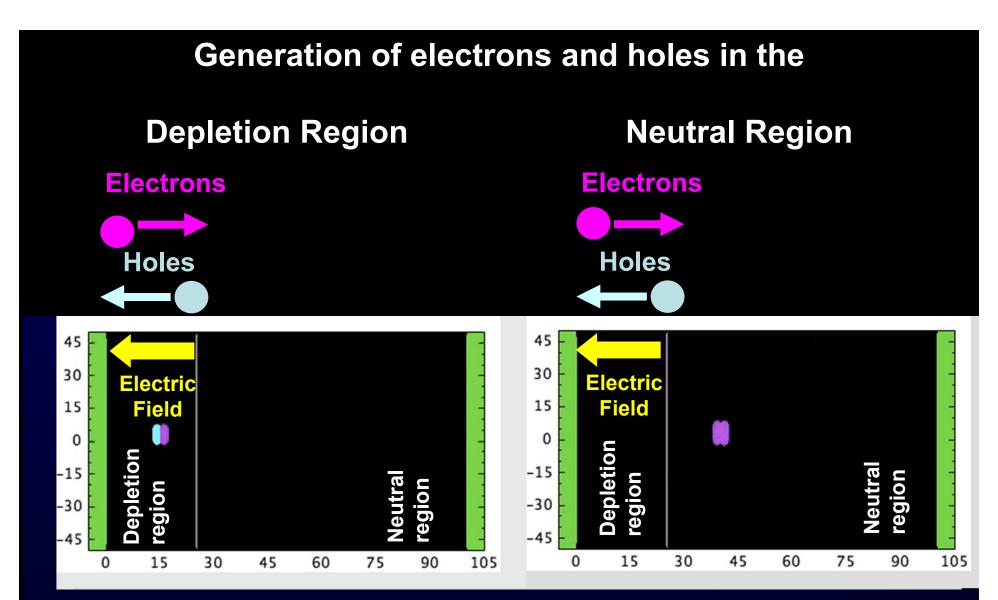
$$I(t) = q \cdot \frac{v}{d}$$

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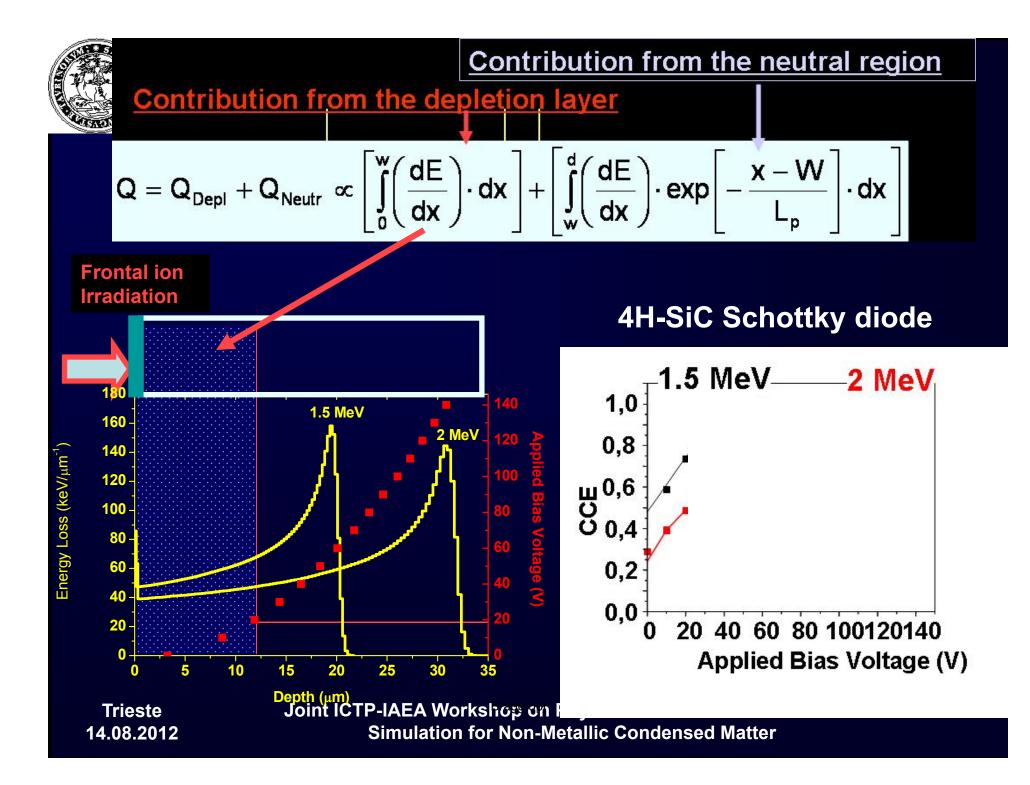
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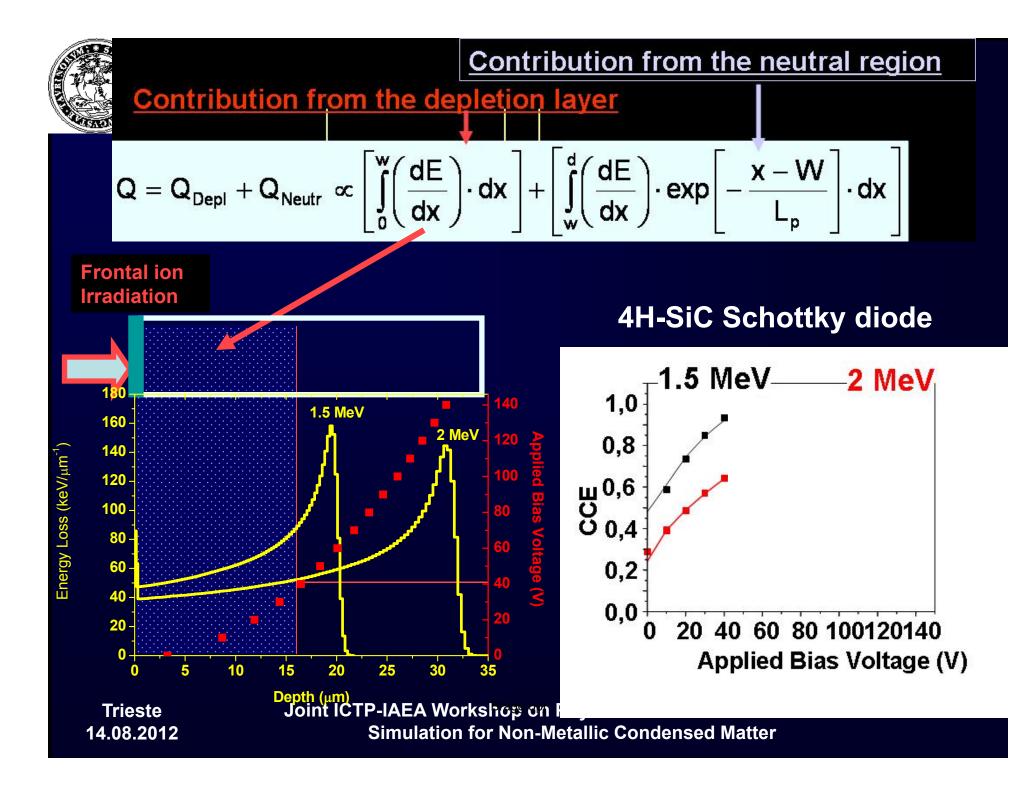


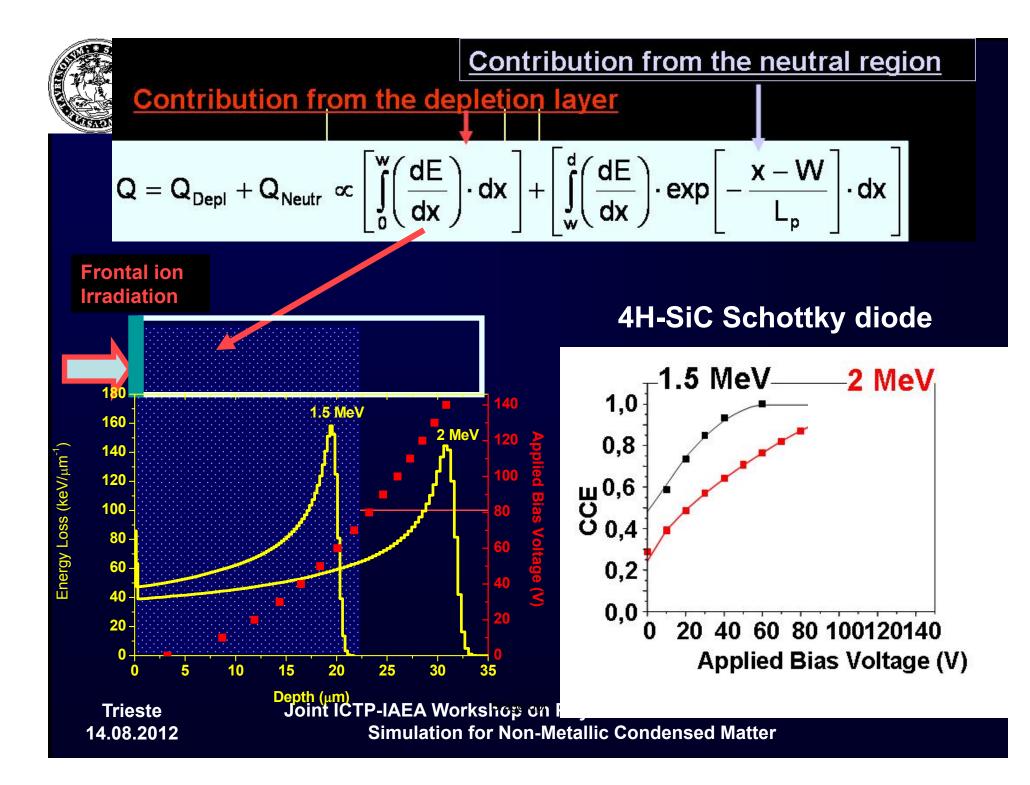
Complete charge collection

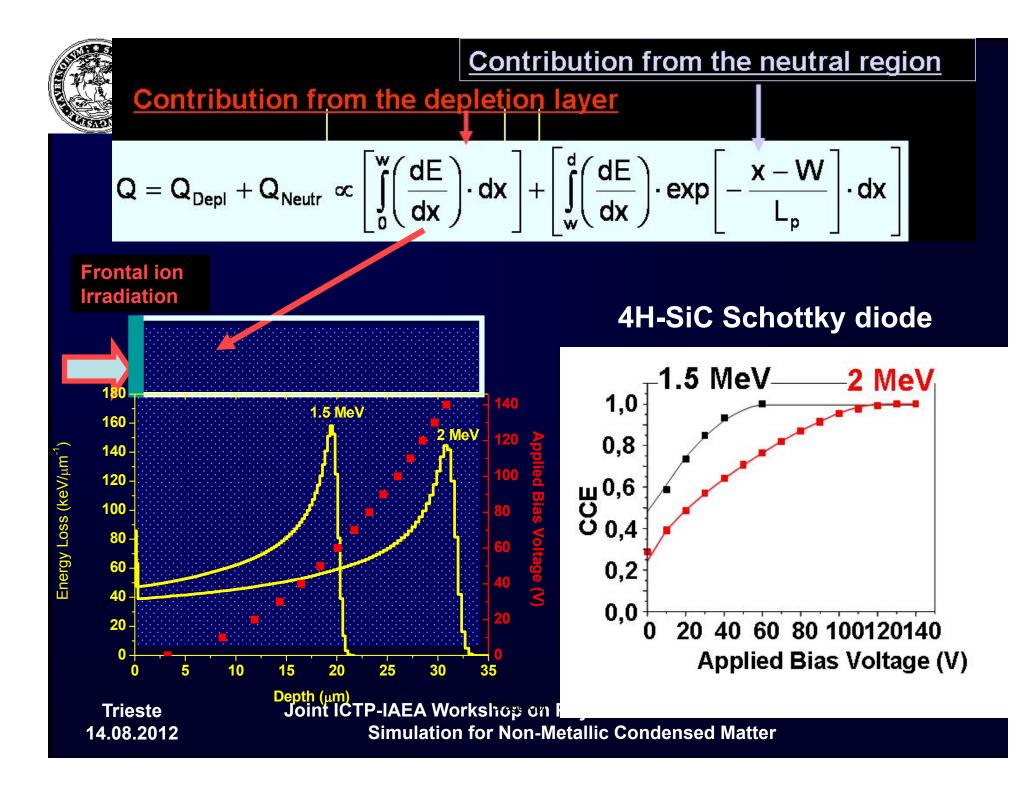
Only holes injected in the depletion region by diffusion induce a charge

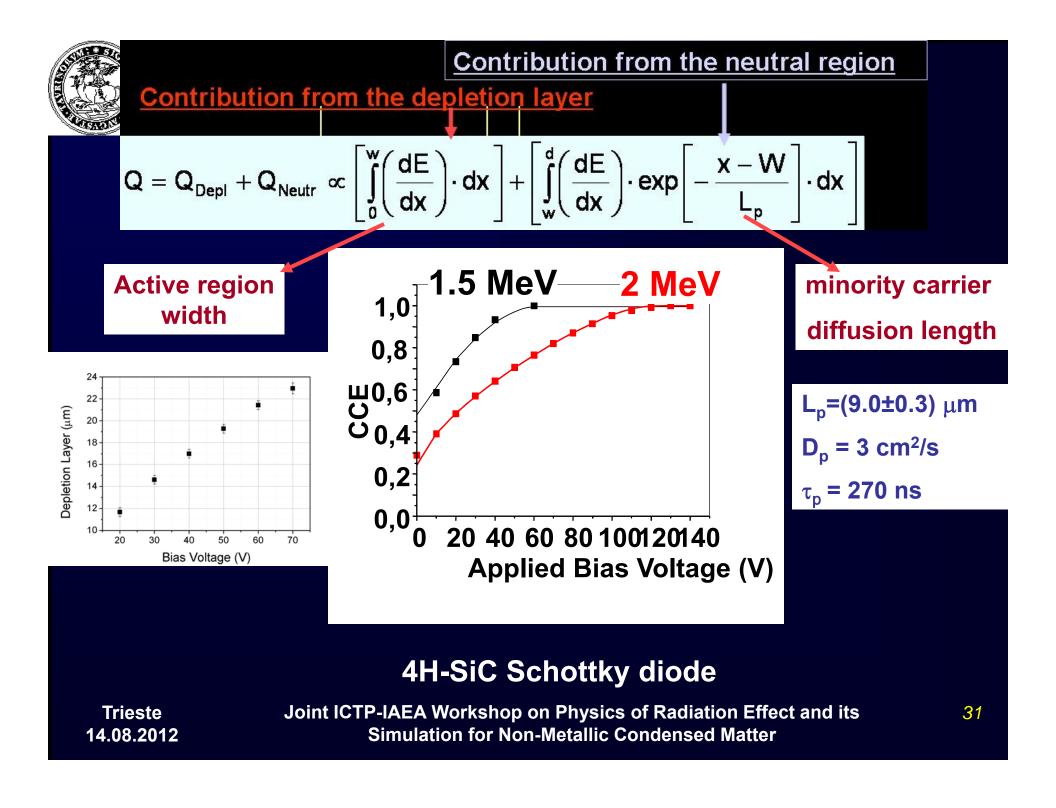
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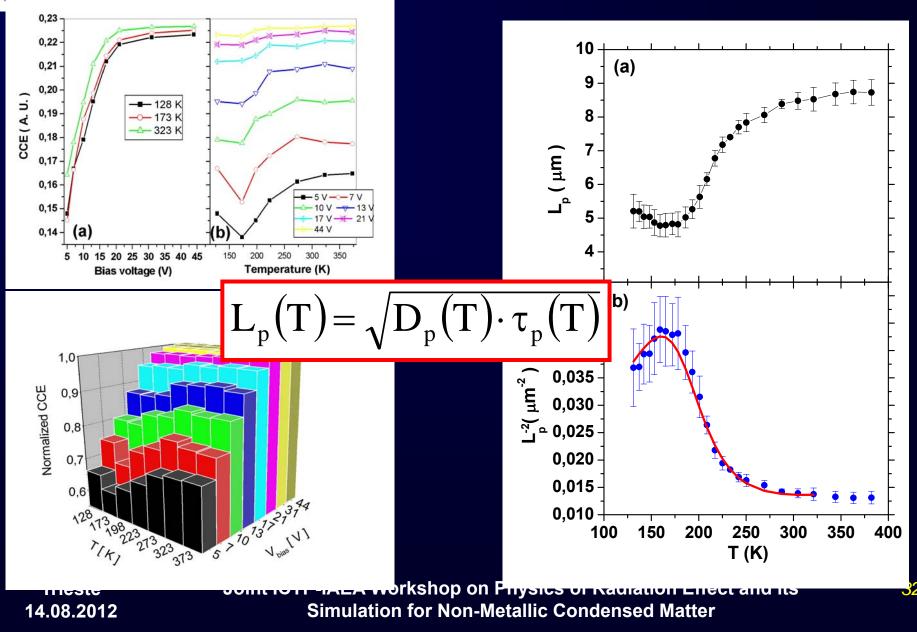






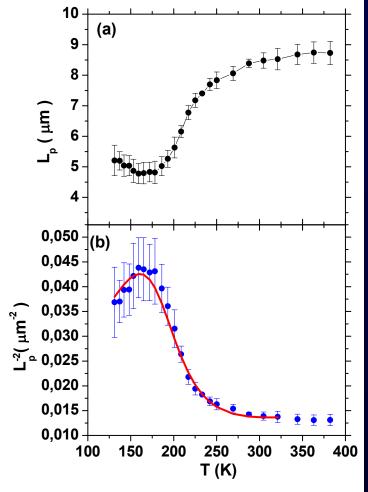


Temperature dependent IBIC (TIBIC)





Temperature dependent IBIC (TIBIC)



Two trapping levels SRH recombination model

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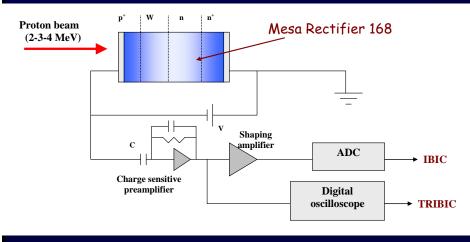
$$\frac{1}{L_{p}^{2}} = \frac{1}{D_{p} \cdot \tau} = \frac{1}{D_{p}} \cdot \left(\frac{1}{\tau(T)} + \frac{1}{\tau_{B}}\right) = A \cdot \frac{1}{T^{-0.5}} \cdot \left(\frac{1}{T^{-0.5} + \frac{B}{N_{D}} \cdot T \cdot exp\left(-\frac{E_{t}}{k_{B}T}\right)} + \frac{1}{\tau_{B}}\right)$$

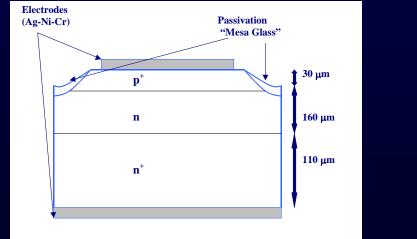
The fitting procedure provides a trapping level of about 0.163 eV which is close to the value found in similar 4H SiC Schottky diodes by DLTS technique (S1 level).

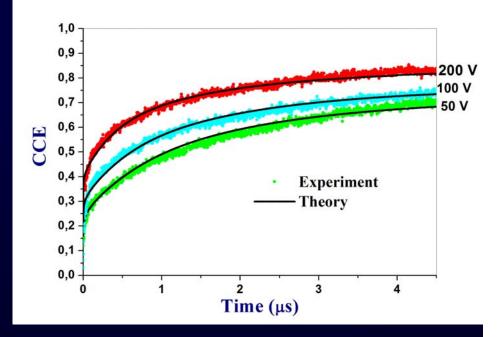
E. Vittone et al., NIM-B 231 (2005) 491.

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Time resolved IBIC (TRIBIC) Silicon Power diode Mesa Rectifier







Ballistic deficit

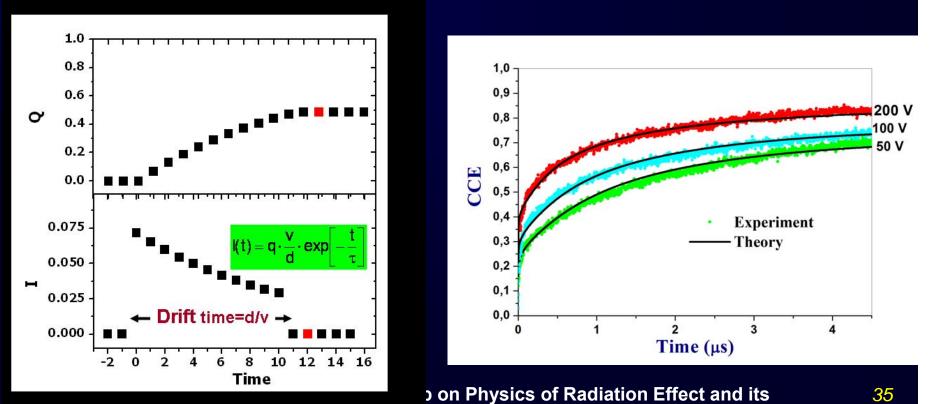
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Joint ICTP-IAEA Workshop on Physics of Radiation Effect and its Simulation for Non-Metallic Condensed Matter <u>34</u>

Time resolved IBIC (TRIBIC) Silicon Power diode Mesa Rectifier

lifetime $\tau_0 = (5 \pm 1) \mu s$

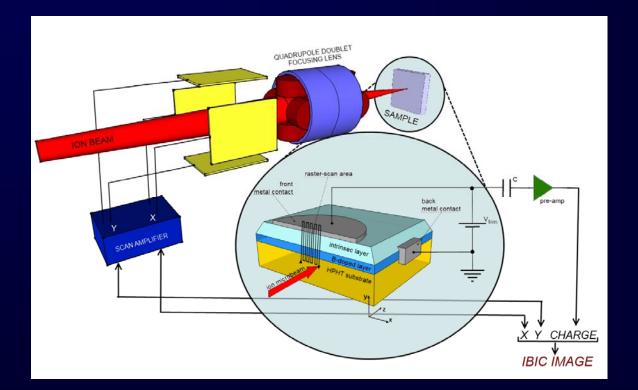


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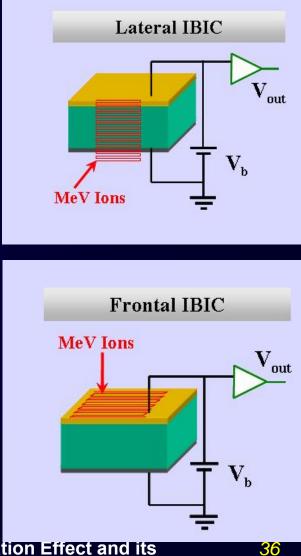
Simulation for Non-Metallic Condensed Matter



From Spectroscopy to micro-spectroscopy



Use of focused ion beams

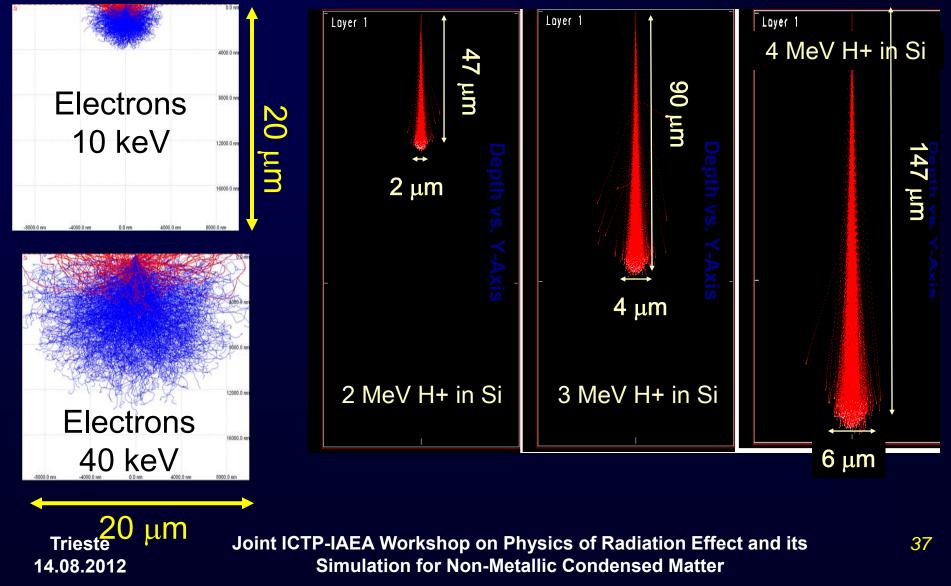


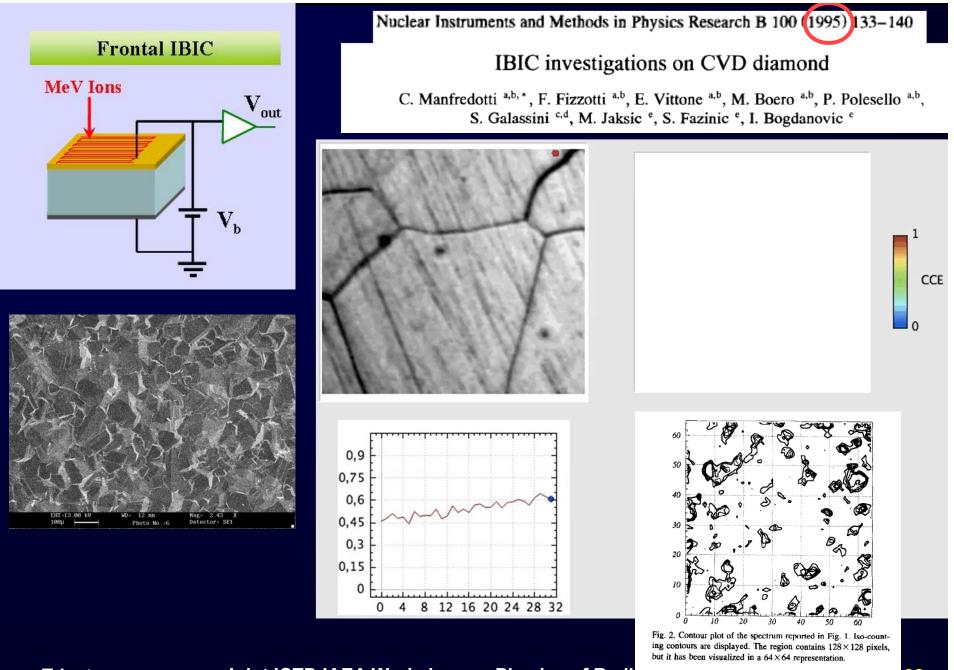
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Trajectories

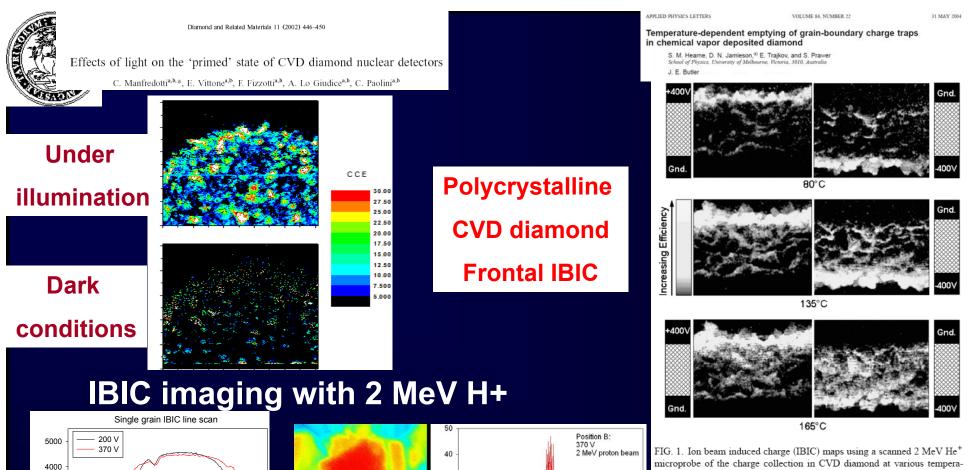
One advantage of IBIC over other forms of charge collection microscopy is that it provides high spatial resolution analysis in thick layers since the focused MeV ion beam tends to stay 'focused' through many micrometers of material.





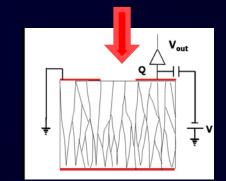
Trieste 14.08.2012 Joint ICTP-IAEA Workshop on Physics of Radiation Enect and its Simulation for Non-Metallic Condensed Matter

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50 100 150 200 250 Position (nm)

FIG. 1. Ion beam induced charge (IBIC) maps using a scanned 2 MeV He⁺ microprobe of the charge collection in CVD diamond at various temperatures. The location of the electrodes is shown. Note that the charge collection efficiency is always highest near to the anode.



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Intra-crystallite charge transport

M.B.H.Breese et al. NIM-B 181 (2001), 219-224; P.Sellin et al. NIM-B 260 (2007), 293-294

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2000 Sounts

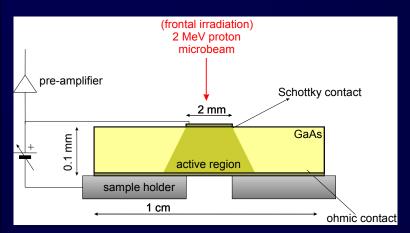
2000

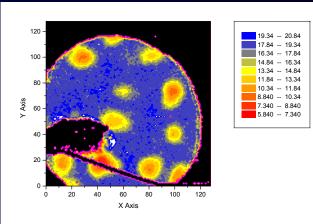
1000

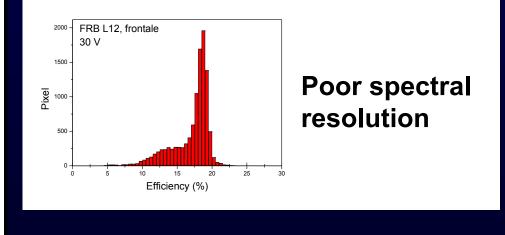
0 +



GaAs Schottky diode Frontal IBIC

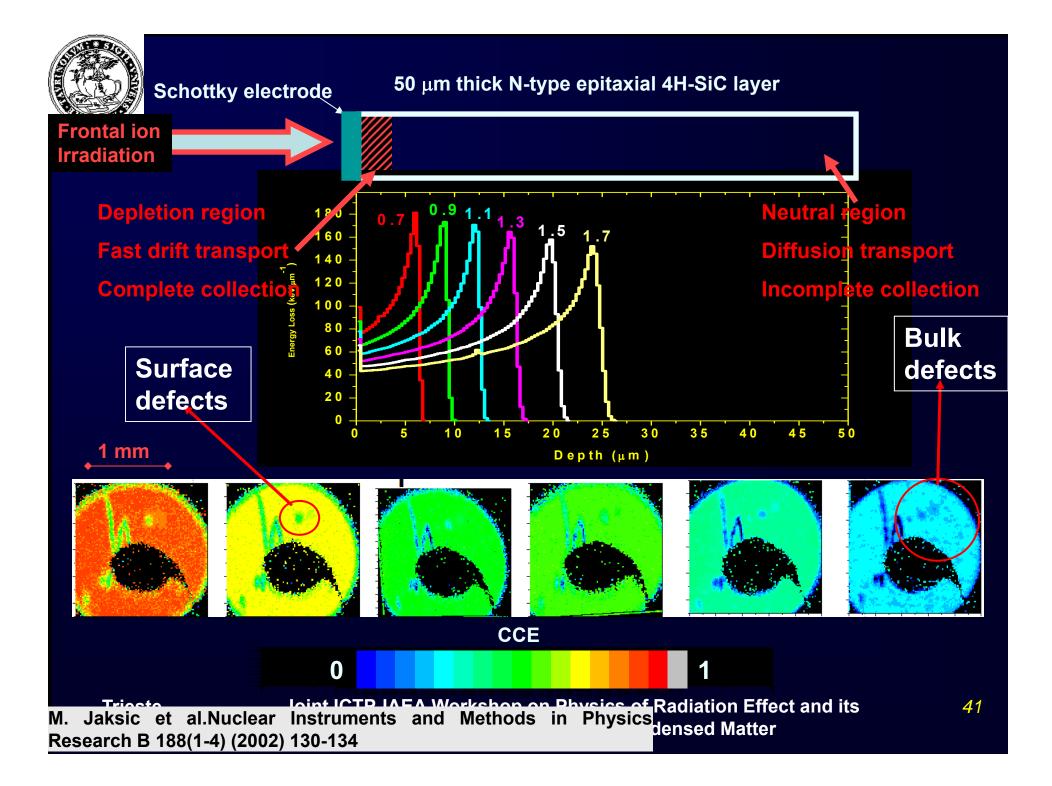


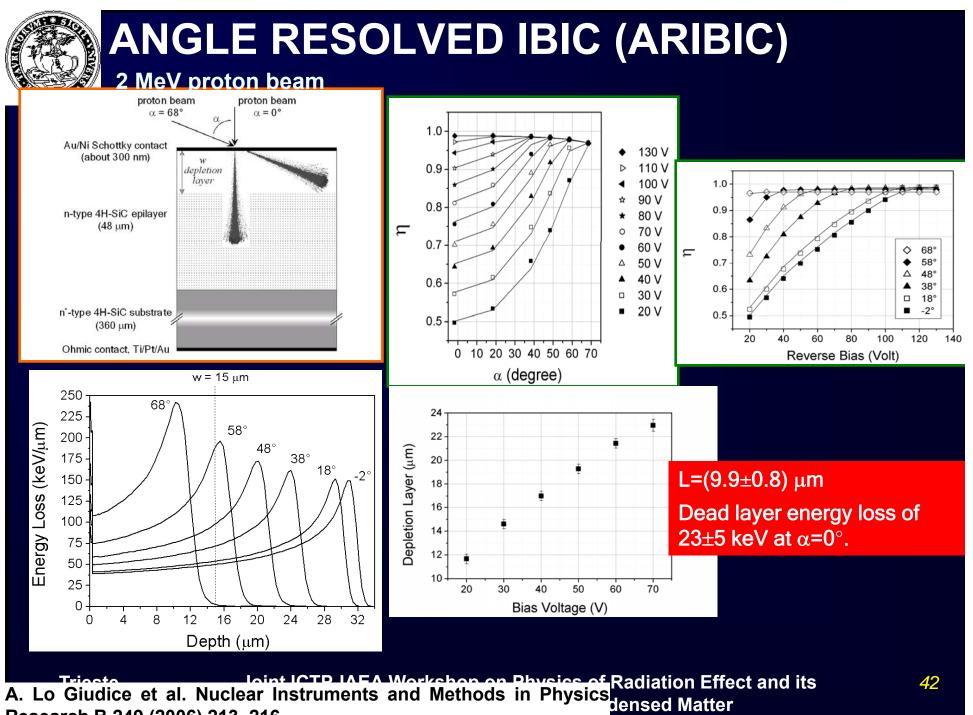




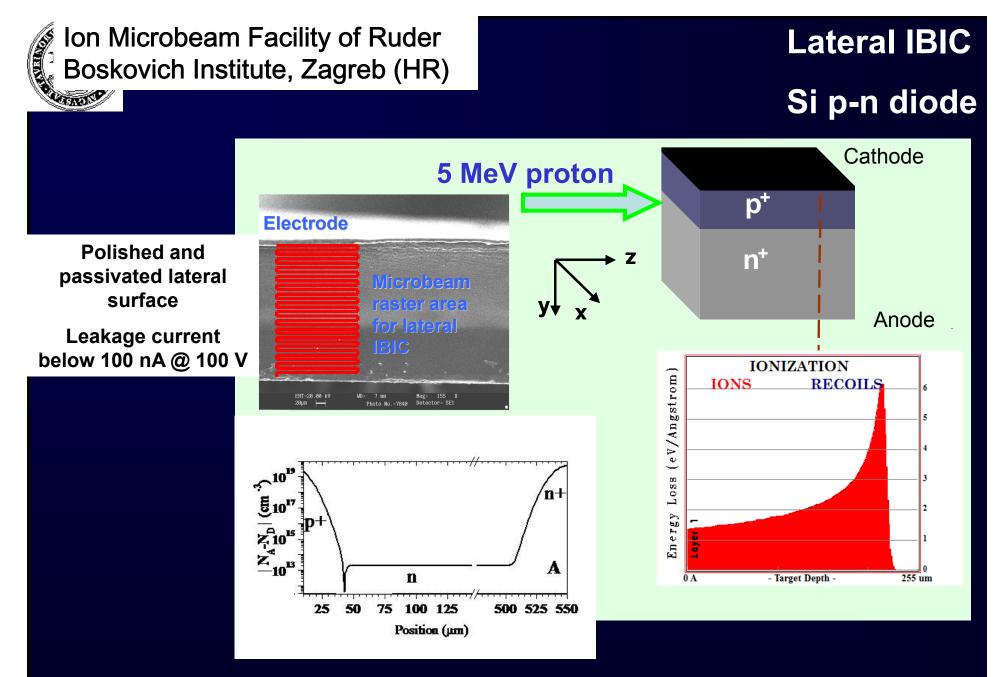
Effects of inhomogeneous cabon doping

E. Vittone et al., Nuclear instruments and Methods in Physics of Radiation Effect and its Research B 158 (1999) 470-47



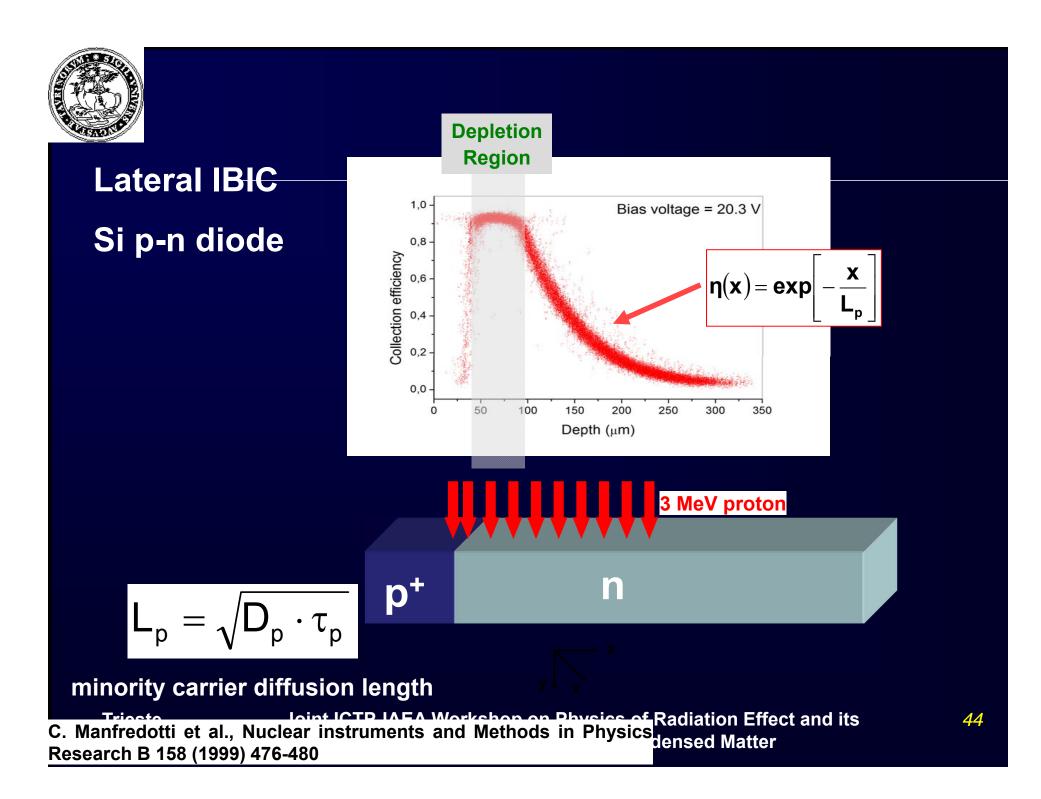


Research B 249 (2006) 213-216



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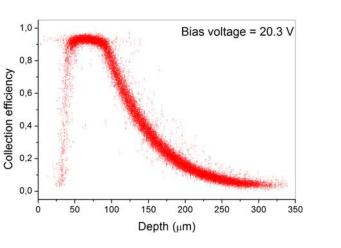
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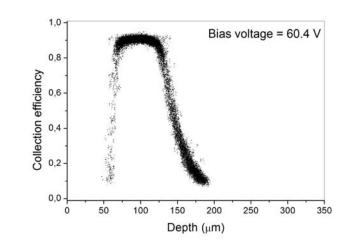


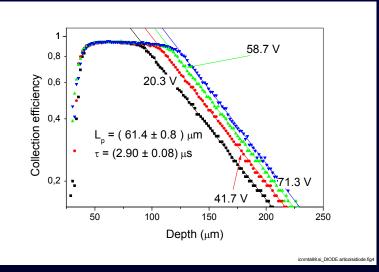


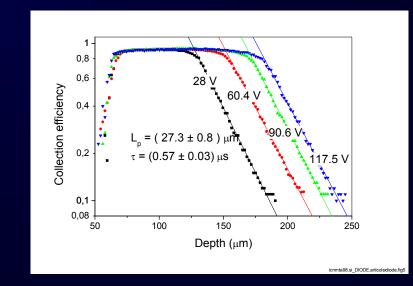
Pristine diode











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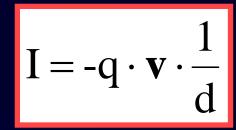


Pulse shapes calculation

Shockley-Ramo theorem

Currents to Conductors Induced by a Moving Point Charge

W. SHOCKLEY Bell Telephone Laboratories, Inc., New York, N. Y. (Received May 14, 1938) Currents Induced by Electron Motion* SIMON RAMO†, ASSOCIATE MEMBER, I.R.E.



Gunn theorem

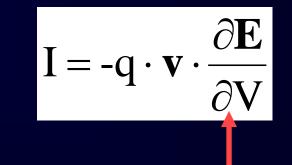
Solid-State Electronics Pergamon Press 1964. Vol. 7, pp. 739-742. Printed in Great Britain

A GENERAL EXPRESSION FOR ELECTROSTATIC INDUCTION AND ITS APPLICATION TO SEMICONDUCTOR DEVICES [°]

> J. B. GUNN IBM Watson Research Center, Yorktown Heights, New York

(Received 2 March 1964; in revised form 26 March 1964)

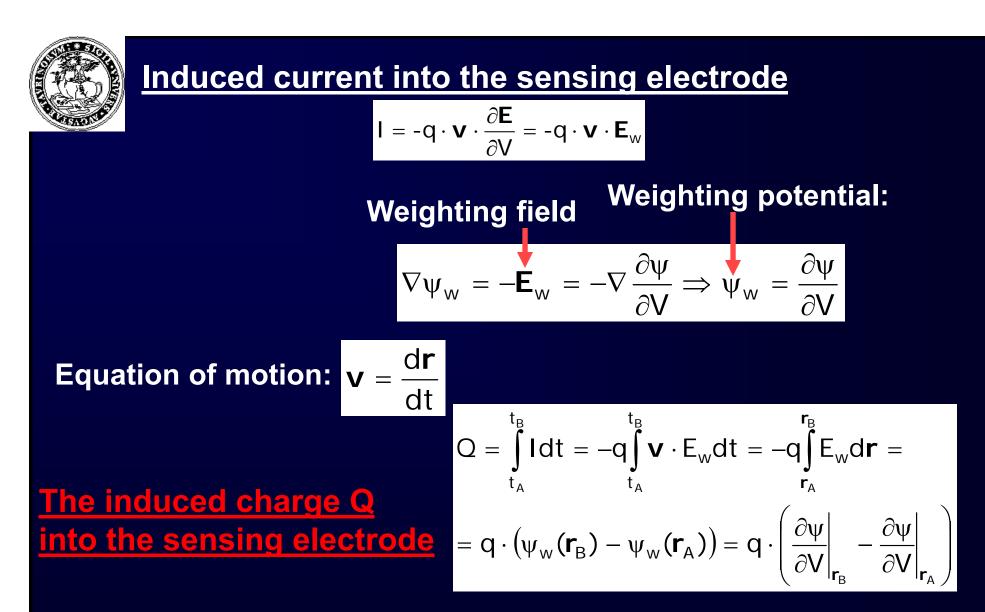
Abstract—A new formula is deduced, under rather general conditions, for the charges induced upon a system of conductors by the motion of a small charge nearby. The conditions are found under which this result can be simplified to yield various previously derived formulas applicable to the problem of collector transit time in semiconductor devices.



Weighting field

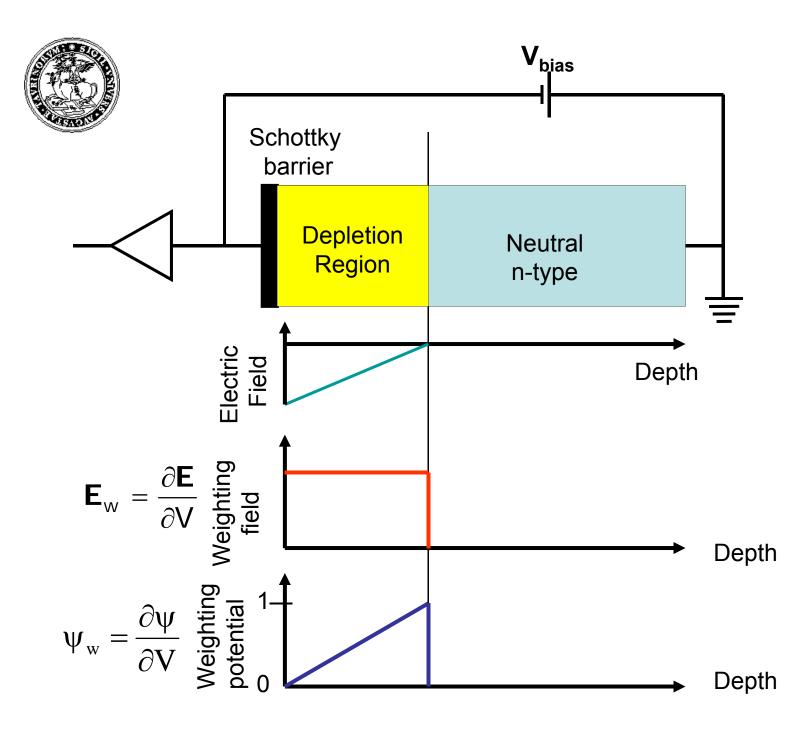
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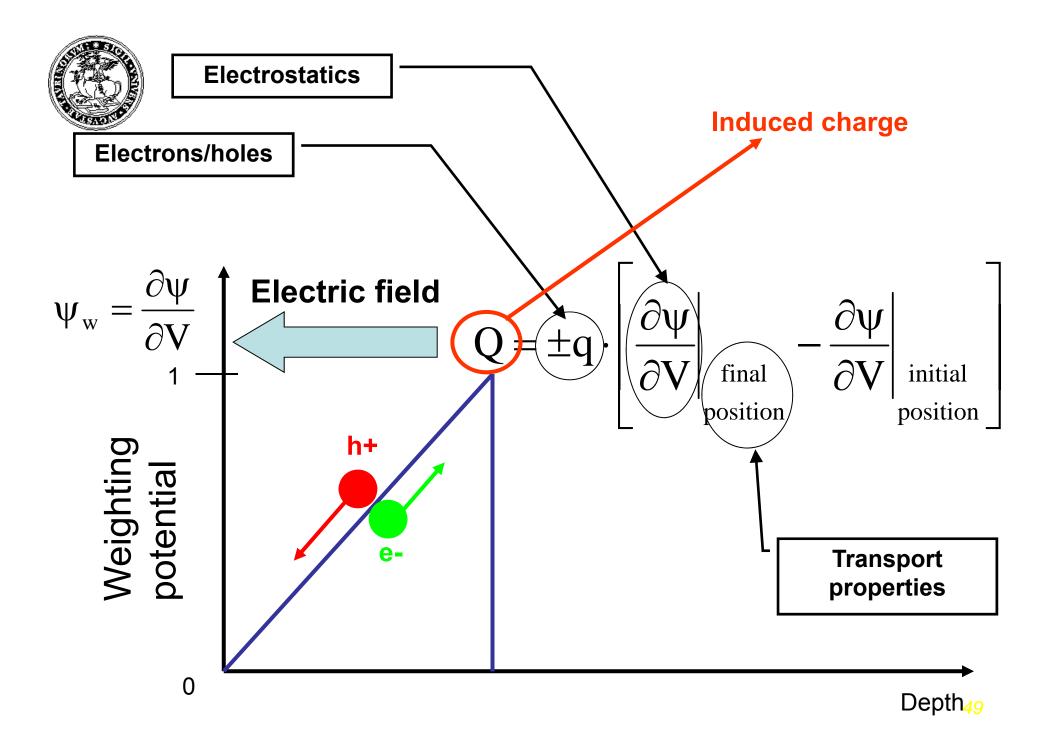
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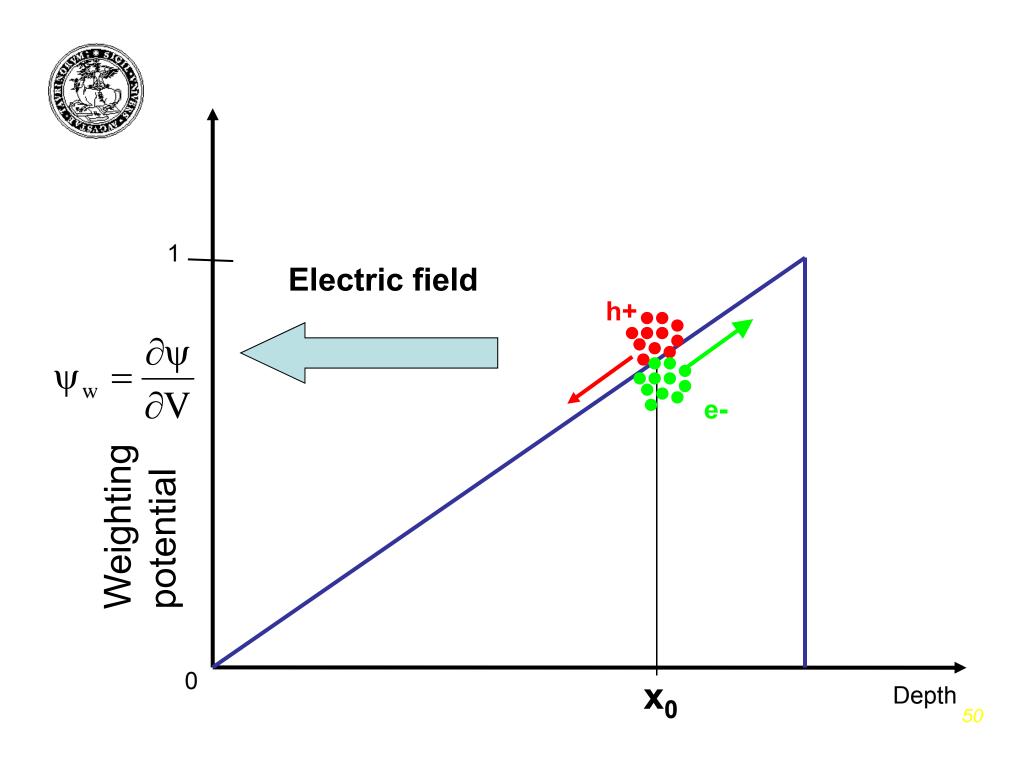


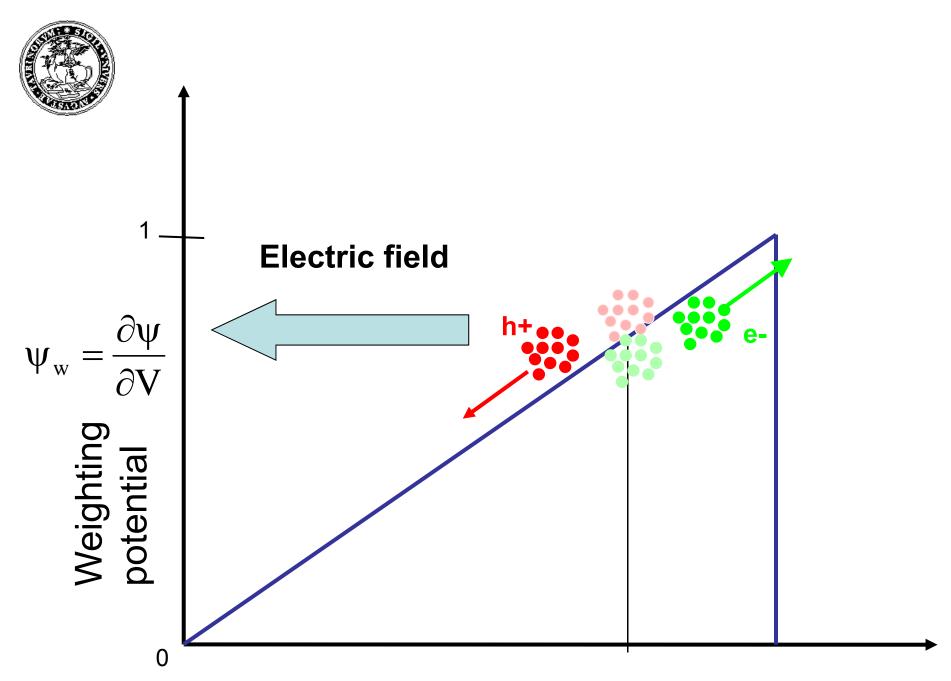
is given by the difference in the weighting potentials between any two positions (r_A and r_B) of the moving charge

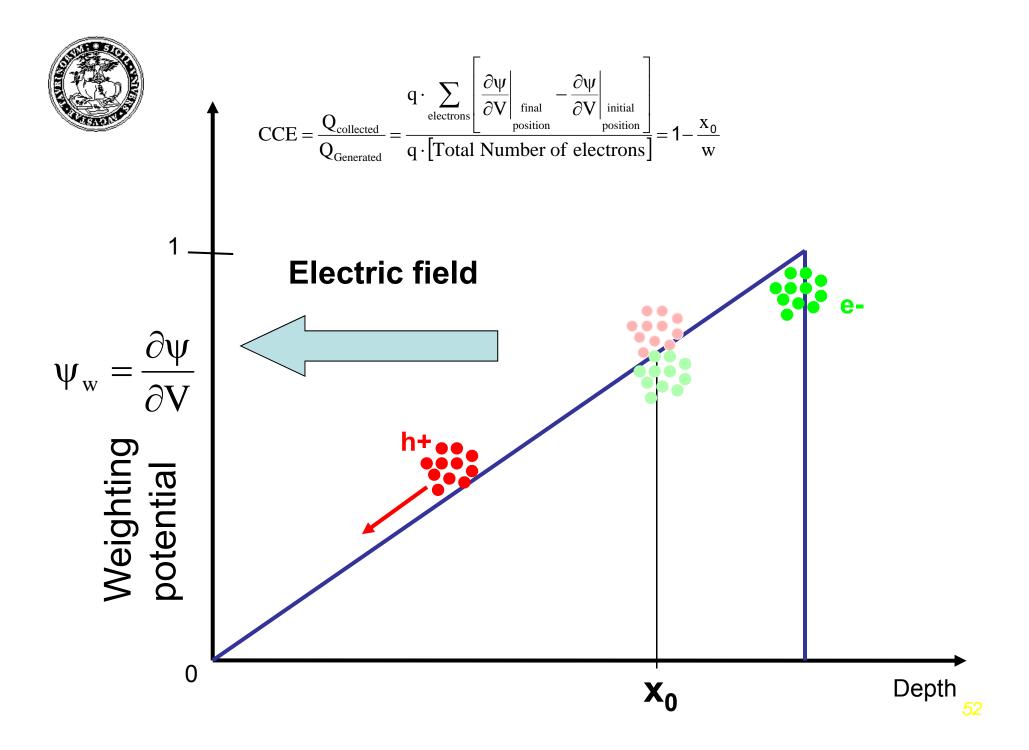
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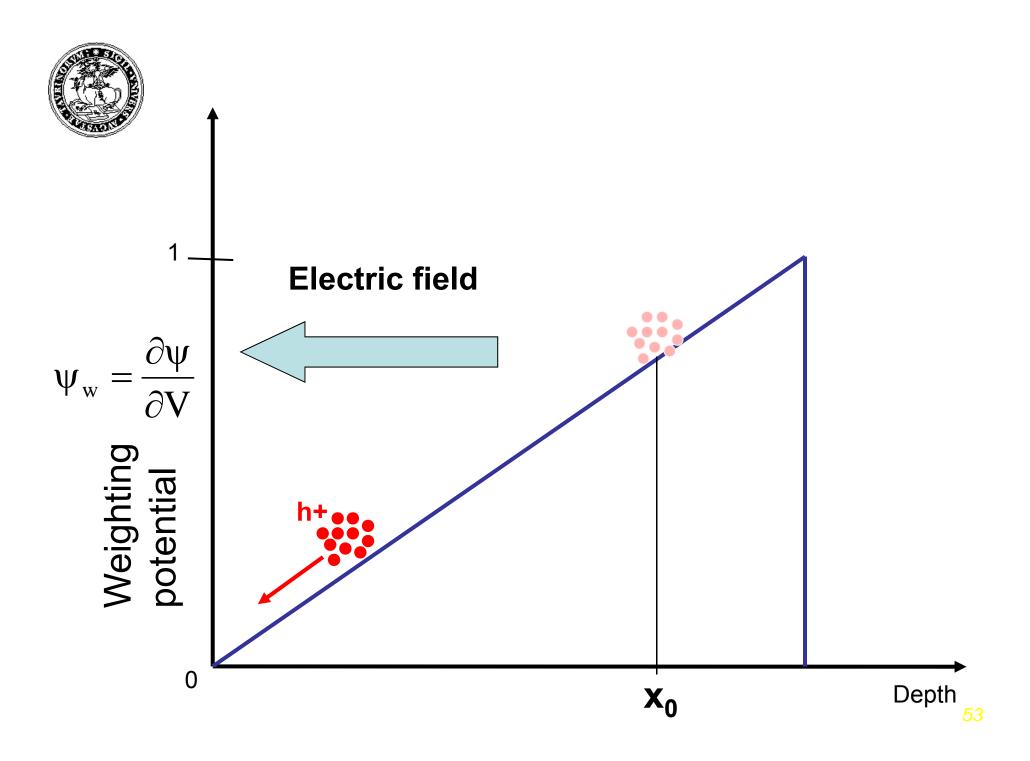


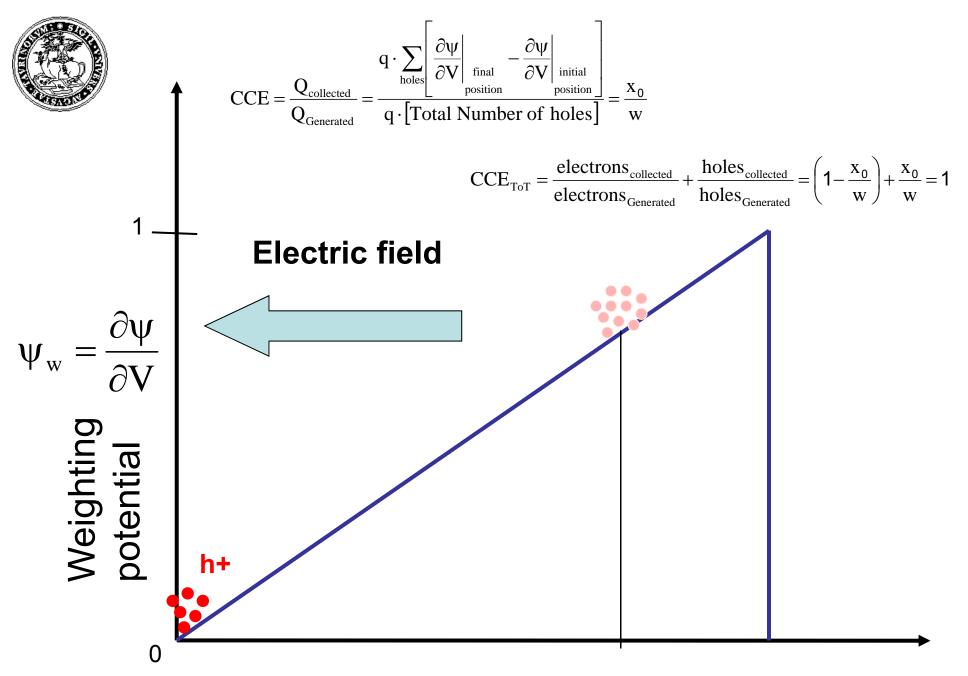














To evaluate the total induced charge

Evaluate the actual potential ψ by solving the Poisson's equation

Magnetic effects are negligible;

Electric field propagates instantaneously

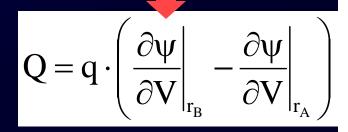
Free carrier velocities much smaller than the light speed

Excess charge does not significantly perturb the electric field

Evaluate the Gunn's weighting potential $\frac{\partial \psi}{\partial V}$ V is the bias potential at the sensitive electrode

Solve the transport (continuit y) equations

The induced charge Q into the sensing electrode is given by the difference in the weighting potentials between any two positions (r_A and r_B) of the moving charge

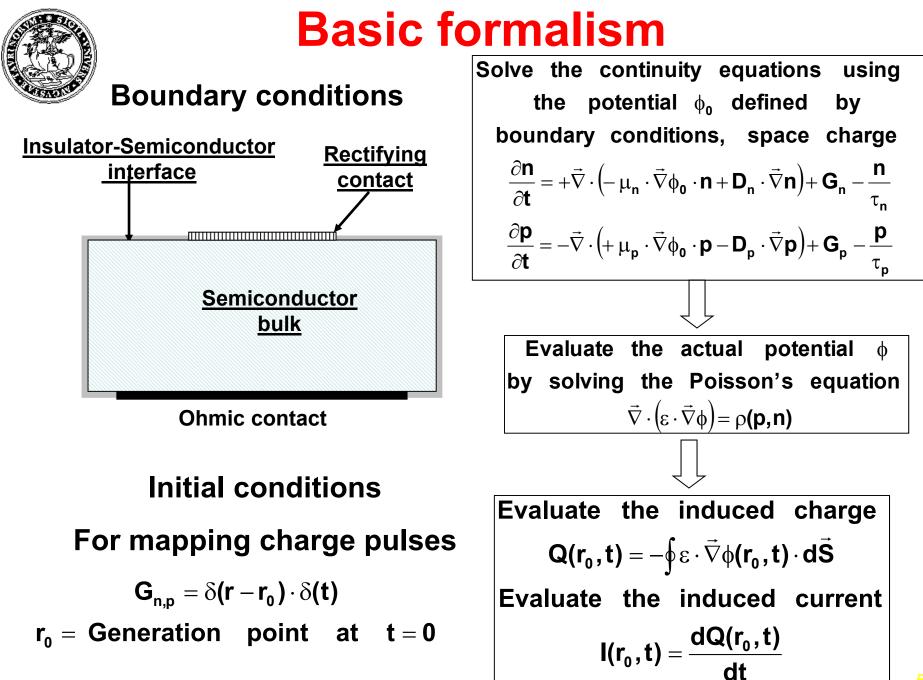


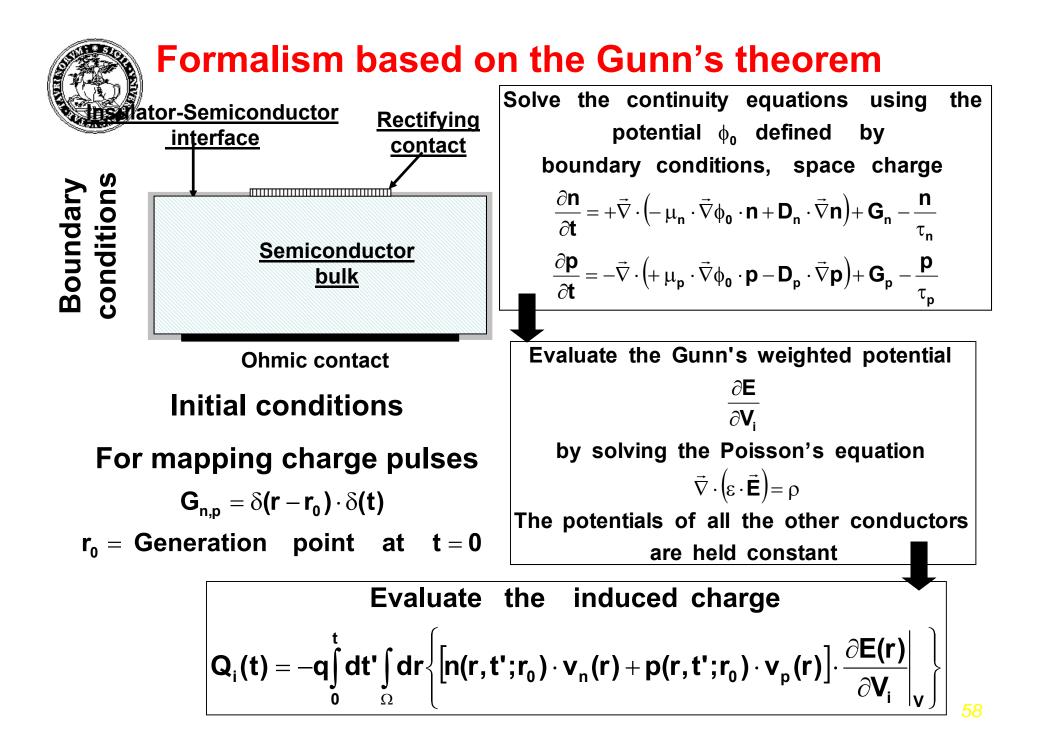
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Basic assumptions

Free velocities carrier Magnetic effects are negligible; much smaller than the light **Electric field propagates instantaneously** speed ELECTROSTATICS Excess charge does not $\begin{cases} \frac{\partial \mathbf{n}}{\partial \mathbf{t}} = \vec{\nabla} \cdot \vec{\mathbf{J}}_{n} + \mathbf{G}_{n} - \mathbf{U}_{n} \\ \frac{\partial \mathbf{p}}{\partial \mathbf{t}} = -\vec{\nabla} \cdot \vec{\mathbf{J}}_{p} + \mathbf{G}_{p} - \mathbf{U}_{p} \\ \vec{\nabla} \cdot \left(\varepsilon \cdot \vec{\nabla} \phi \right) = \rho(\mathbf{p}, \mathbf{n}) \end{cases}$ significantly perturb the field within the detector Quasi-steady-state mode $\begin{cases} \frac{\partial \mathbf{n}}{\partial \mathbf{t}} = \vec{\nabla} \cdot \vec{\mathbf{J}}_{\mathbf{n}} + \mathbf{G}_{\mathbf{n}} - \mathbf{U}_{\mathbf{n}} \\ \frac{\partial \mathbf{p}}{\partial \mathbf{t}} = -\vec{\nabla} \cdot \vec{\mathbf{J}}_{\mathbf{p}} + \mathbf{G}_{\mathbf{p}} - \mathbf{U}_{\mathbf{p}} \\ \vec{\nabla} \cdot \left(\varepsilon \cdot \vec{\nabla} \phi \right) = \rho(\mathbf{p}, \mathbf{n}) \end{cases}$ Linearization of U $\frac{\partial \mathbf{n}}{\partial \mathbf{t}} = \vec{\nabla} \cdot \vec{\mathbf{J}}_{\mathbf{n}} + \mathbf{G}_{\mathbf{n}} - \frac{\mathbf{n}}{\tau_{\mathbf{n}}}$ $\begin{aligned} \frac{\partial \boldsymbol{p}}{\partial \boldsymbol{t}} &= -\vec{\nabla} \cdot \vec{\boldsymbol{J}}_{\boldsymbol{p}} + \boldsymbol{G}_{\boldsymbol{p}} - \frac{\boldsymbol{p}}{\tau_{\boldsymbol{p}}} \\ \vec{\nabla} \cdot \left(\boldsymbol{\epsilon} \cdot \vec{\nabla} \boldsymbol{\phi} \right) &= \rho(\boldsymbol{p}, \boldsymbol{n}) \end{aligned}$







$$\mathbf{Q}_{in}(\mathbf{t}) = -\mathbf{q}_{\mathbf{0}}^{\mathsf{t}} \mathbf{dt'} \int_{\Omega} \mathbf{dr} \left\{ \left[\mathbf{n}(\mathbf{r}, \mathbf{t'}; \mathbf{r}_{\mathbf{0}}) \cdot \mathbf{v}_{\mathbf{n}}(\mathbf{r}) \right] \cdot \frac{\partial \mathbf{E}(\mathbf{r})}{\partial \mathbf{V}_{i}} \right|_{\mathbf{V}} \right\}$$

is the Green's function for the electron continuity equation

The continuity equation The charge induced from involves linear operators solving a single, time dependent adjoint equation.

$$\frac{\partial \mathbf{n}^{+}}{\partial \mathbf{t}} = +\vec{\nabla} \cdot \left(+ \mu_{\mathbf{n}} \cdot \vec{\nabla} \phi_{\mathbf{0}} \cdot \mathbf{n}^{+} + \mathbf{D}_{\mathbf{n}} \cdot \vec{\nabla} \mathbf{n}^{+} \right) + \mathbf{G}^{*}_{\mathbf{n}} - \frac{\mathbf{n}^{+}}{\tau_{\mathbf{n}}} \qquad \mathbf{n}^{+} = \mathbf{Q}_{\mathbf{i}\mathbf{n}} \\ \mathbf{G}^{+}_{\mathbf{n}} = \mu_{\mathbf{n}} \cdot \nabla \phi \cdot \frac{\partial \mathbf{E}}{\partial \mathbf{V}_{\mathbf{i}}}$$

T.H.Prettyman, Nucl. Instr. and Meth. in Phys. Res. A 422 (1999) 232-237.



Monte Carlo Method



Shockley-Ramo-Gunn Theory

A charge moving in a non-zero electric field induces a current to the sensitive electrode.

 $\partial \psi / \partial V$ is the **Gunn's weighting potential**, where ψ is the electric potential and V the bias voltage

$$Q = q \left[\left. rac{\partial \psi}{\partial V}
ight|_r - \left. rac{\partial \psi}{\partial V}
ight|_r
ight]$$

Follow the carrier trajectories by a Monte Carlo approach
Taking into account
physical parameters (geometry, electric field, transport properties)
experimental set-up (noise, threshold, beam spot size)



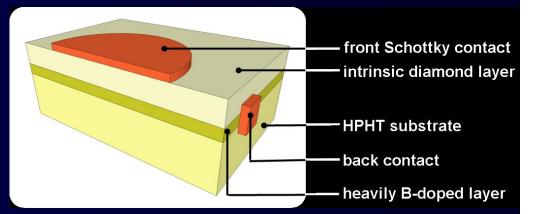
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Lateral IBIC of a diamond Schottky diode

Diamond Schottky diode structure:

- homoepitaxial growth on HPHT substrates
- ✓ (type lb, 4×4×0.4 mm³) slightly B doped (Acceptor concentration ≈ 10^{13} - 10^{14} cm⁻³)
- ✓ heavily B-doped buffer layer as back contact (Acceptor concentration ≈ 10¹⁸-10¹⁹ cm⁻³)
- ✓ 25 µm thick intrinsic layer as active volume
- ✓ Schottky contact: frontal AI circular contact (\emptyset = 2 mm, 200 nm thick) on intrinsic layer
- ✓ back contact on B-doped layer → ohmic contact
- ✓ sample cleaved in order to expose its cross section for IBIC characterization



ideality factor: n = (1.51 ± 0.04) series resistance: R_s = $(5.1 \pm 1.6) k\Omega$ \rightarrow back B-doped contact shunt resistance: R_{sh} = $(900 \pm 6) G\Omega$ @ 50 V -> I<50 pA

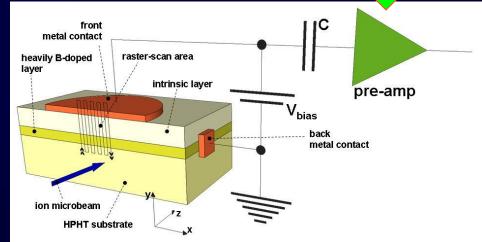
Joint ICTD IAEA Workshop on Physics of Padiation Effect and its

S. Almaviva et al. "Synthetic single crystal diamond dosimeters for conformal radiation therapy application", Diamond & Related Materials 19 (2010) 217–220

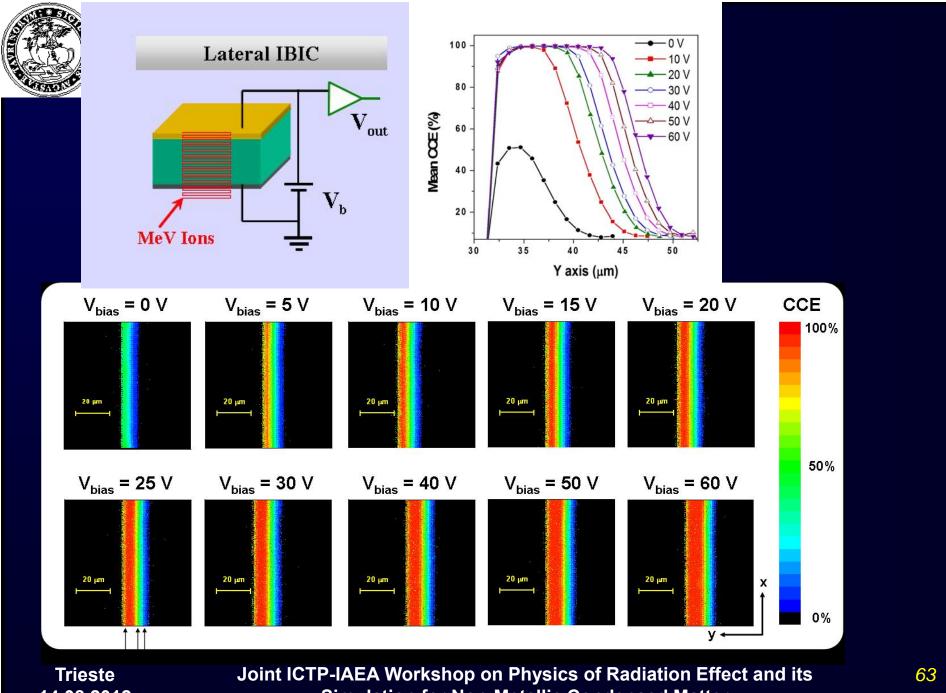


Lateral IBIC measurements performed at the ion microbeam line of the AN2000 accelerator of the National Laboratories of Legnaro (LNL-INFN) charge sensitive electronic chain and synchronous signal acquistition with microbeam scanning

- ✓ ion species and energy: H⁺ @ 2 MeV
- ✓ ion current: ≤ 10³ ions s⁻¹ → no pile up or charging effects
- ✓ ion beam spot on the sample:
 FWHM = 3 µm
- \checkmark raster-scanned area: S = 62×62 μ m²

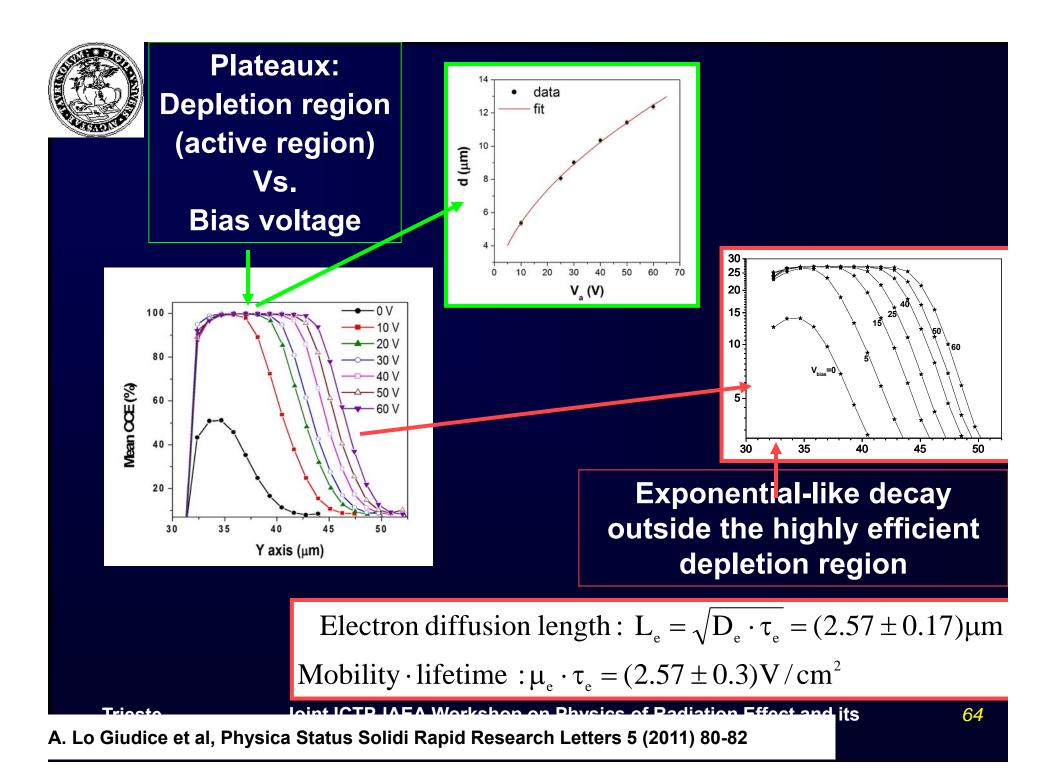


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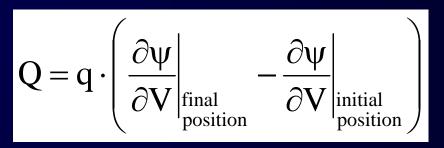
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Simulation for Non-Metallic Condensed Matter

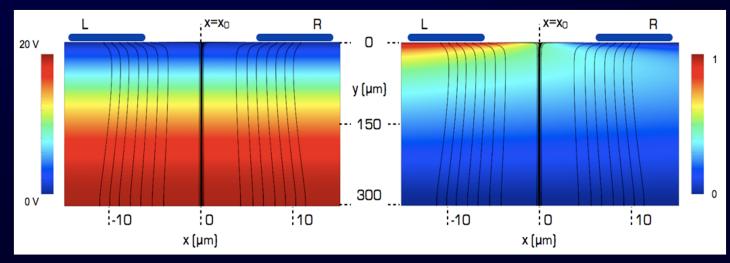




The induced charge Q at the sensing electrode is given by the difference in the weighting potentials between any two positions $(r_A \text{ and } r_B)$ of the moving charge



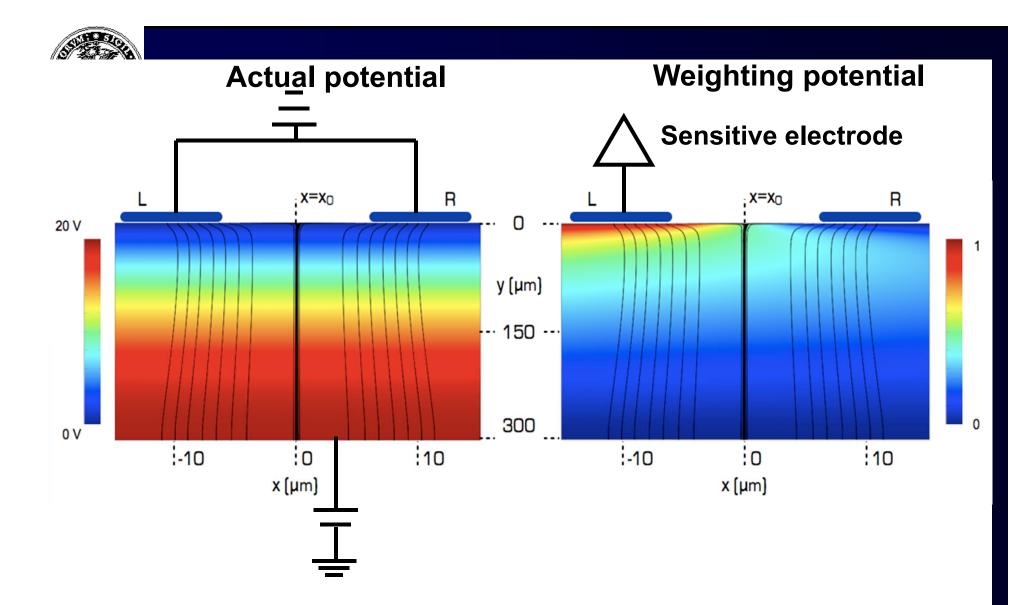
CHARGE SHARING IN MULTIELECTRODE DEVICES



Actual potential

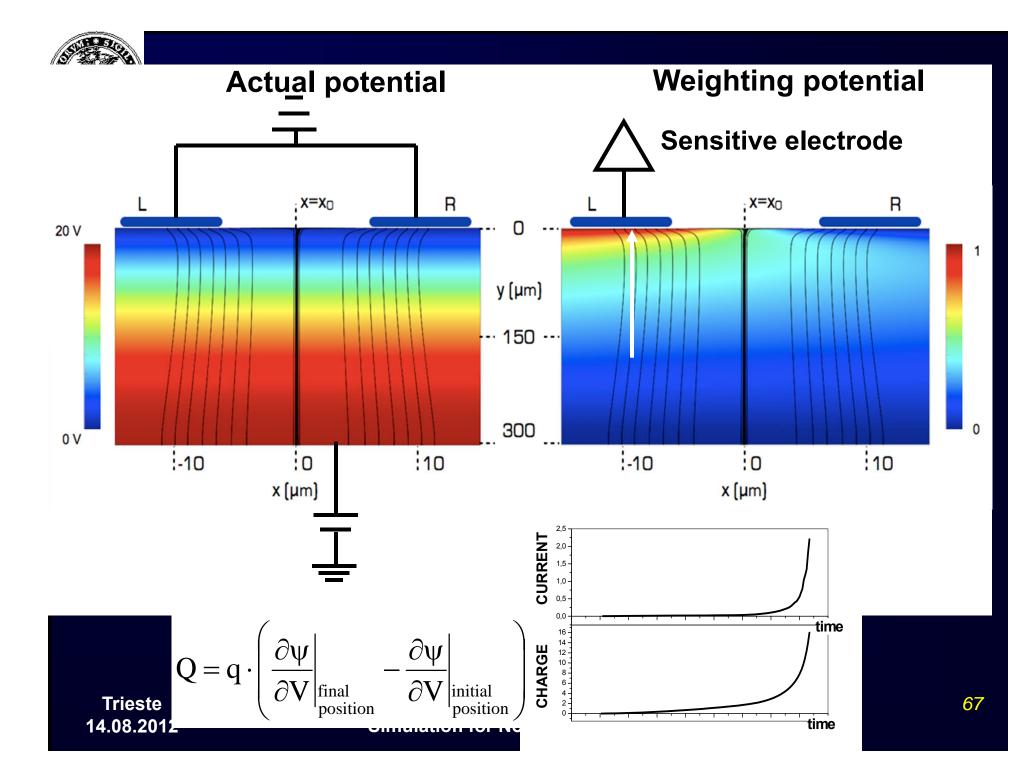
Weighting potential

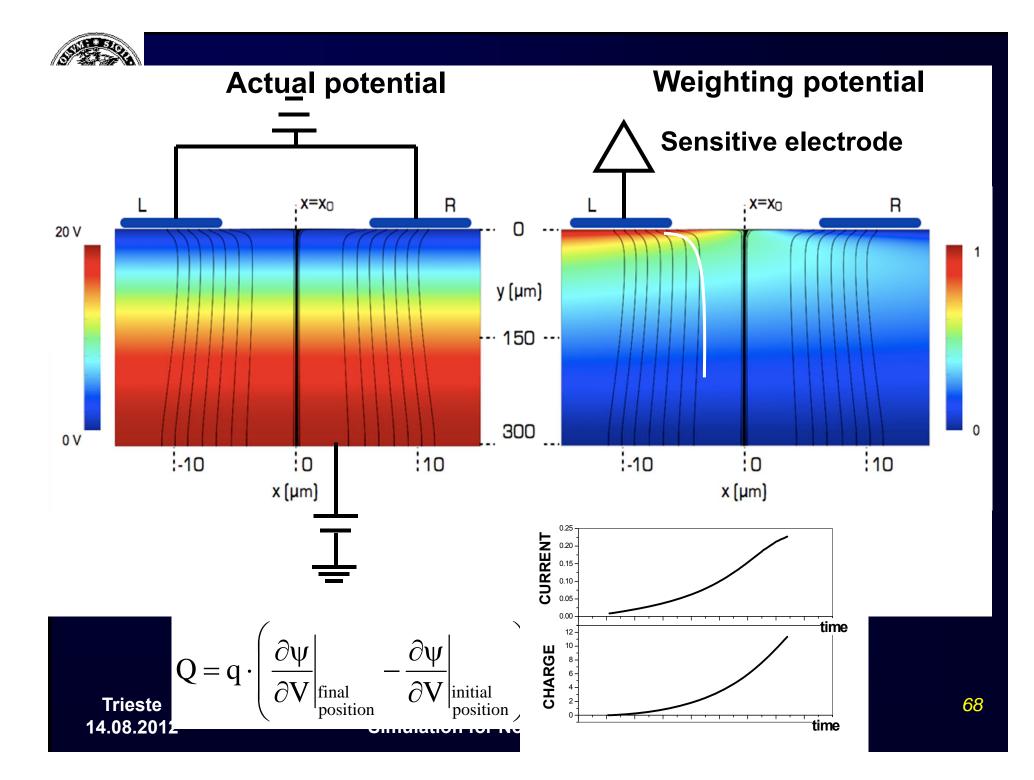
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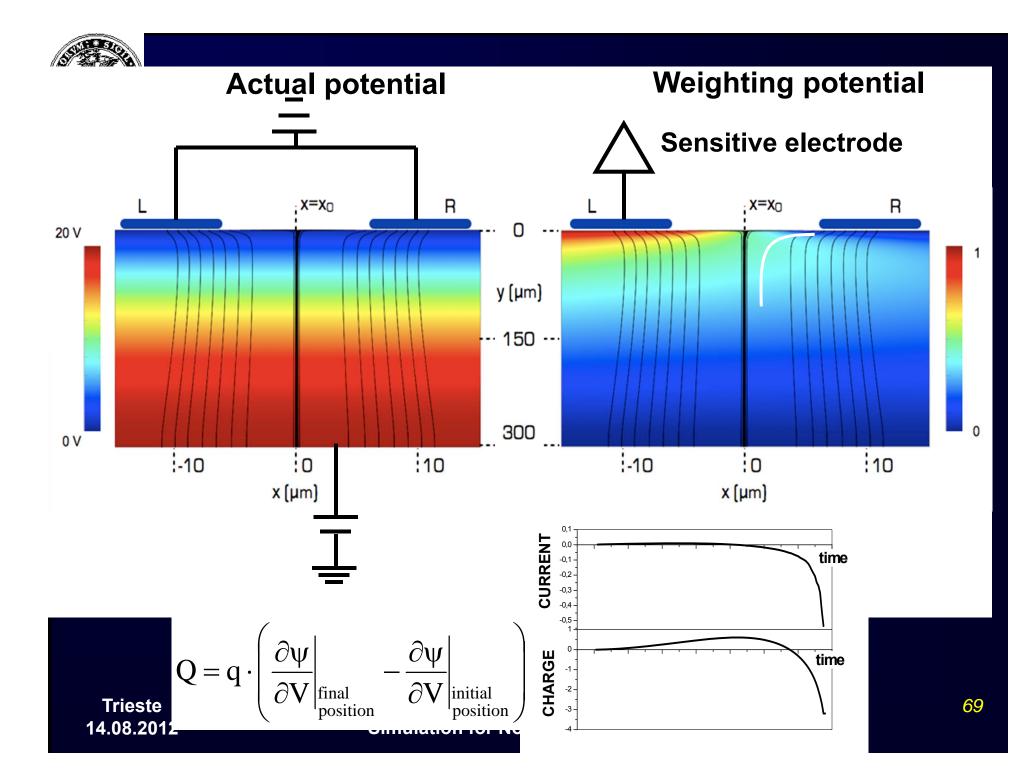


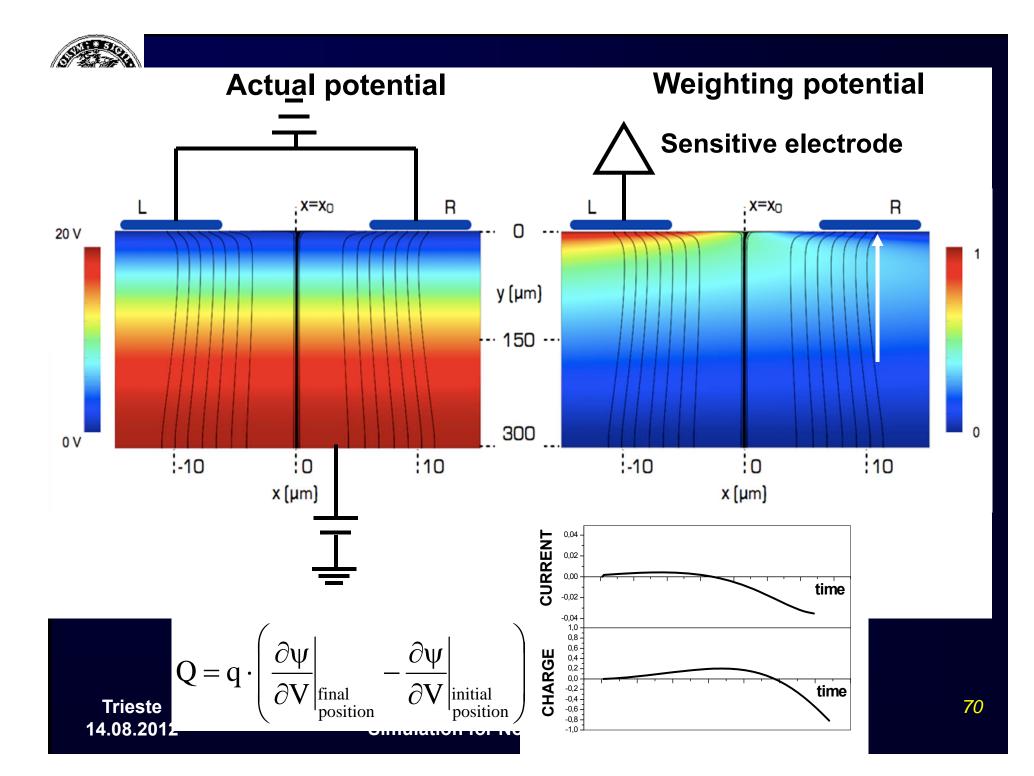
Trieste 14.08.2012 Joint ICTP-IAEA Workshop on Physics of Radiation Effect and its Simulation for Non-Metallic Condensed Matter

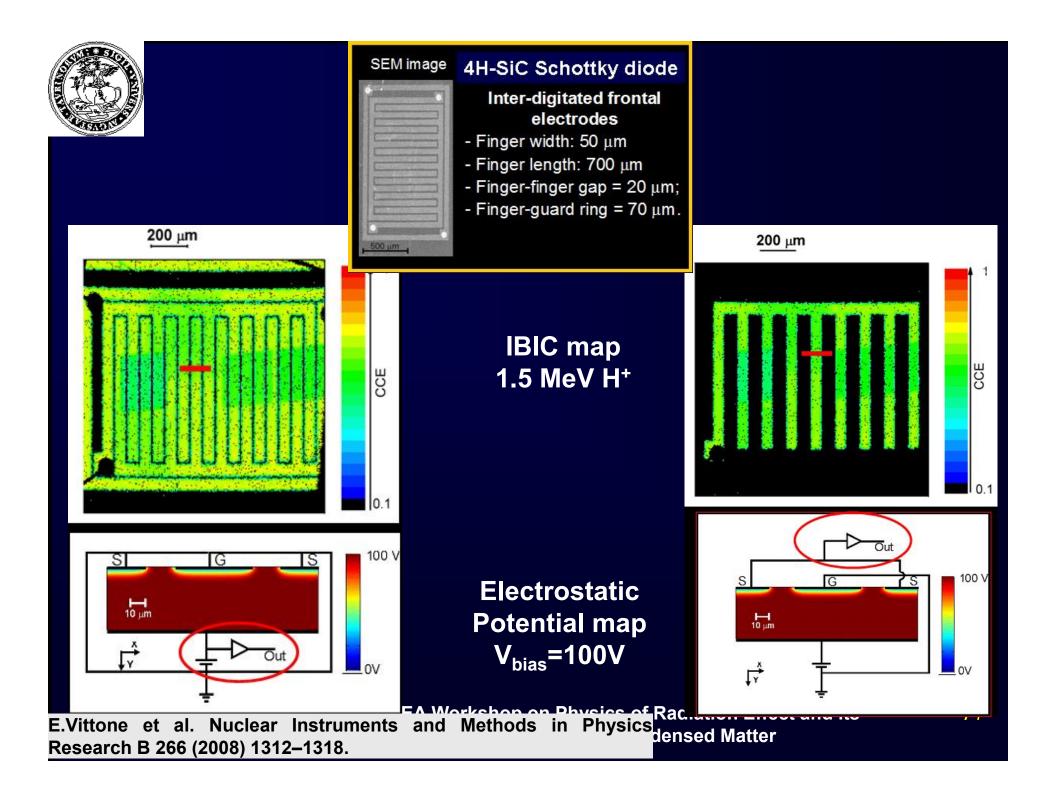
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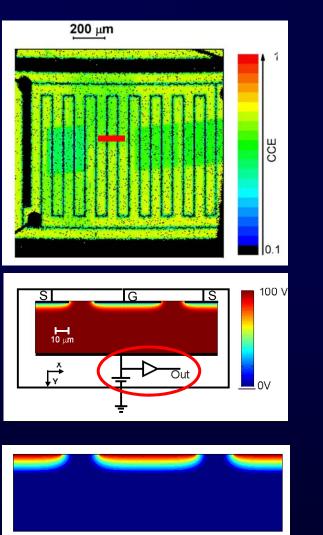


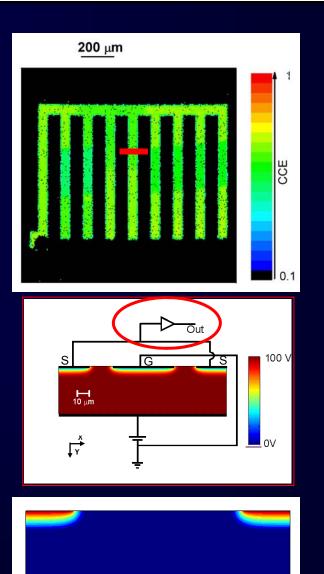






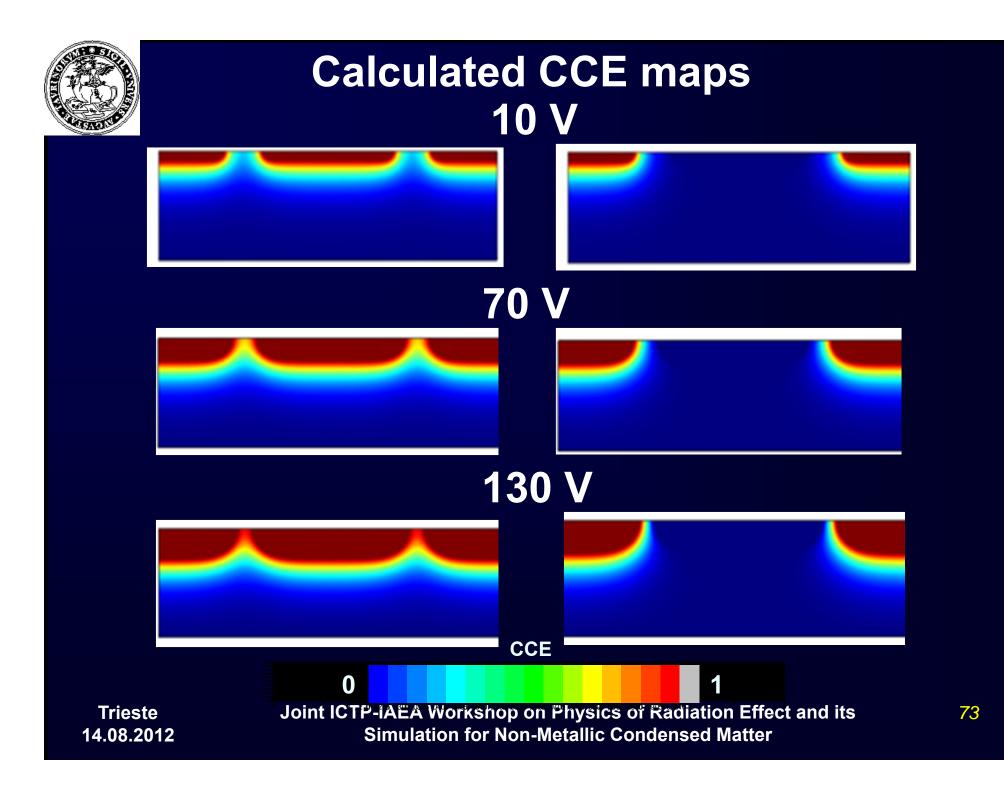






Weighting potential maps

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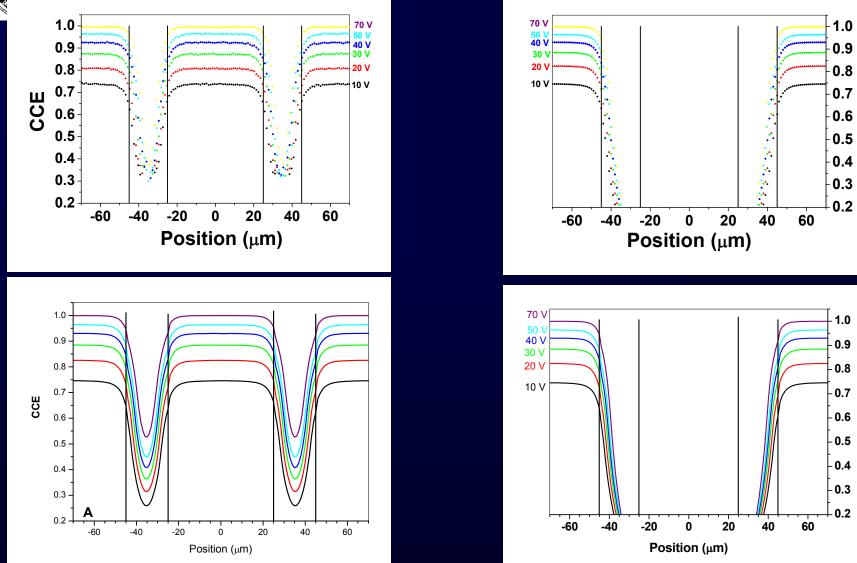


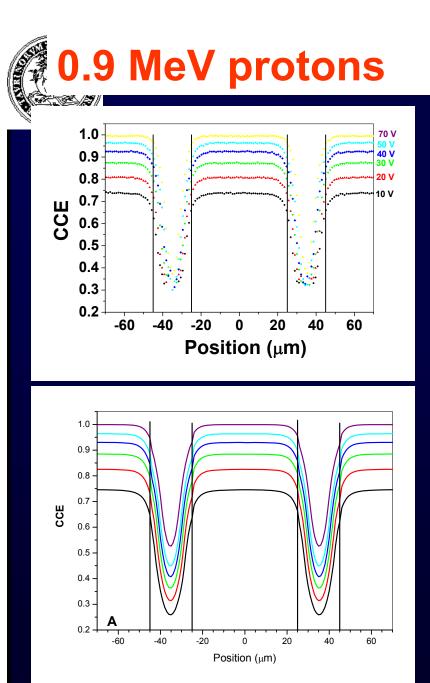


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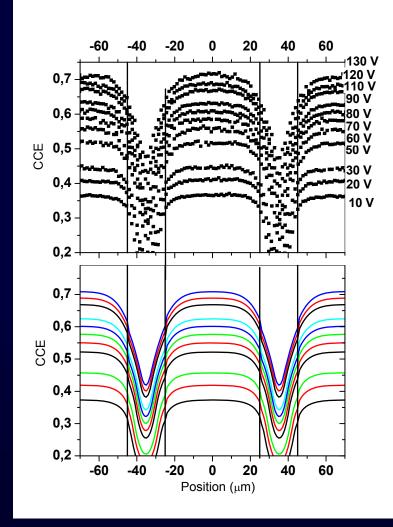
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0.9 MeV protons

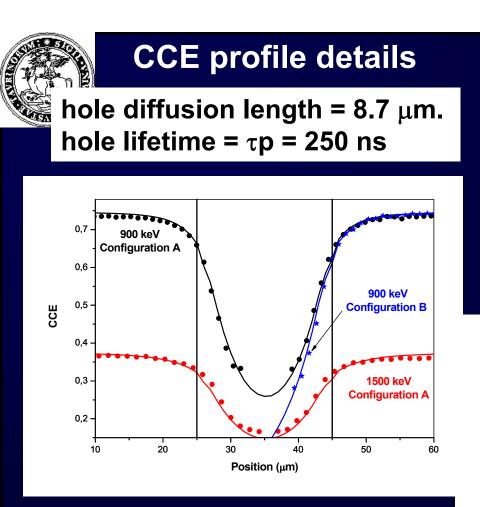


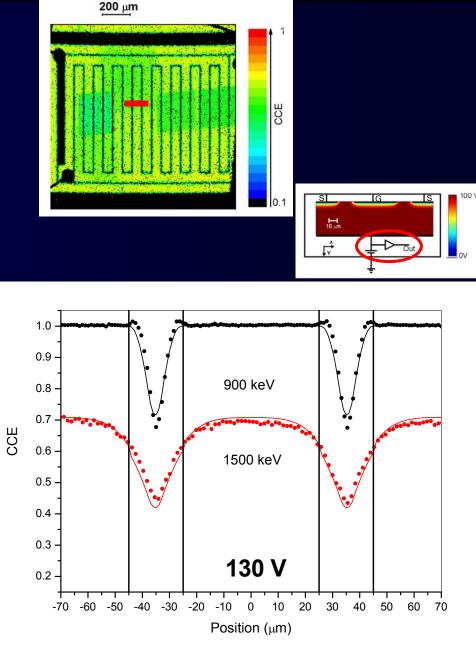


1.5 MeV protons



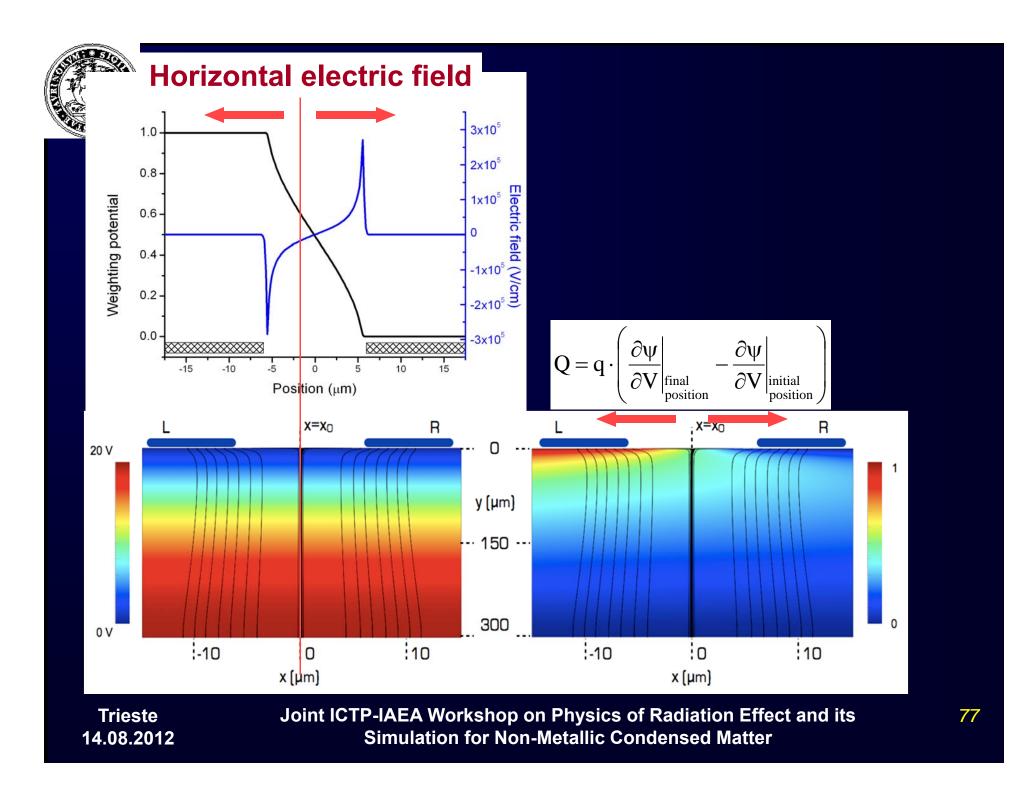
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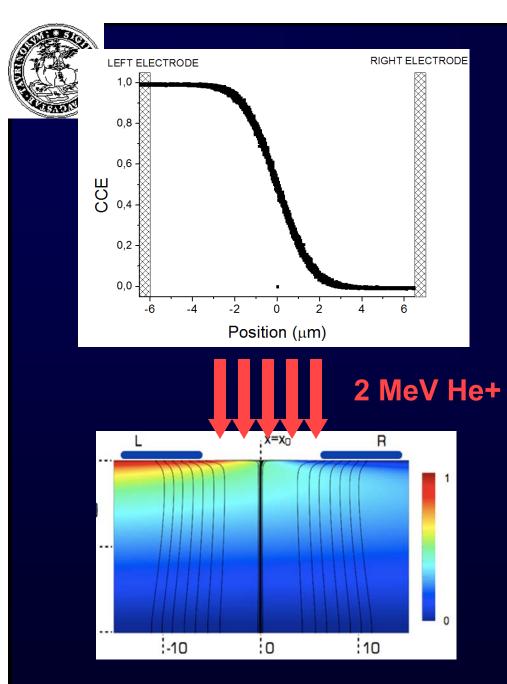




The electrode edges are highlighted by the vertical black line.

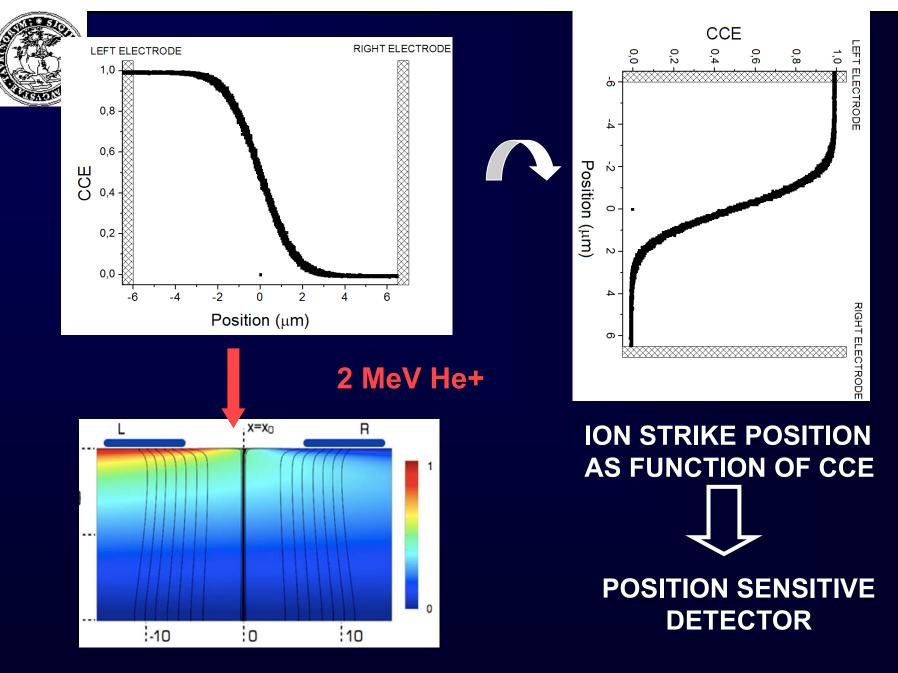
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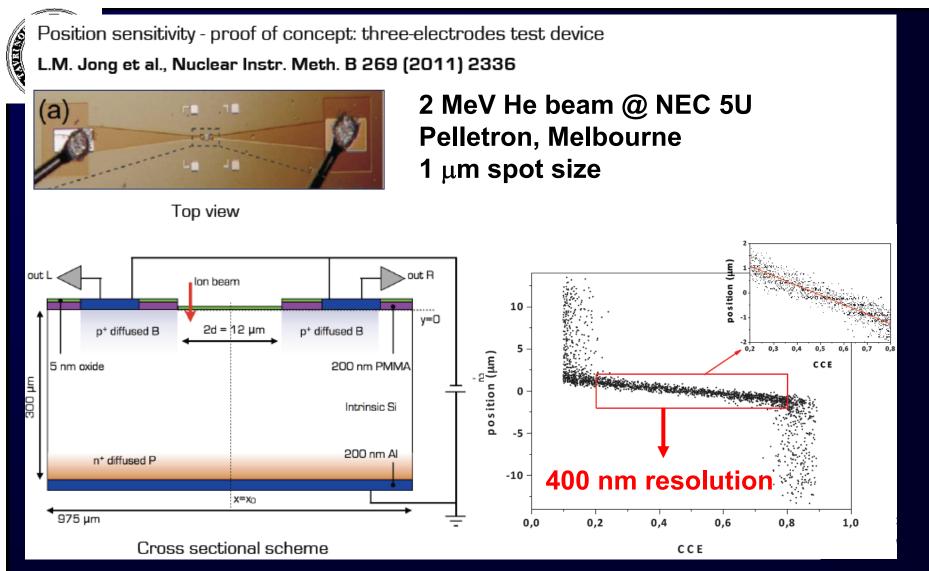


CCE AS FUNCTION OF ION STRIKE POSITION

Trieste 14.08.2012



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J. Forneris et al.

Modeling of ion beam induced charge sharing experiments for the design of high resolution position sensitive detectors, Submitted to NIMB

A SUB-MICROMETER POSITION B SENSITIVE DETECTOR

Trieste 14.08.2012



IBIC

(Ion Beam Induced Charge Collection)

Analytical technique suitable for the measurement of transport properties in semiconductor materials and devices

Control of in-depth generation profile
 Suitable for finished devices (bulk analysis).
 Micrometer resolution
 CCE profiles: Active layer extension; Diffusion length
 Robust theory; FEM and MC approaches
 Analysis of multi-electrode devices

In-situ analysis of radiation damage

Trieste 14.08.2012



Thanks Jacopo for the Applets



Thanks for your kind attention



Trieste 14.08.2012